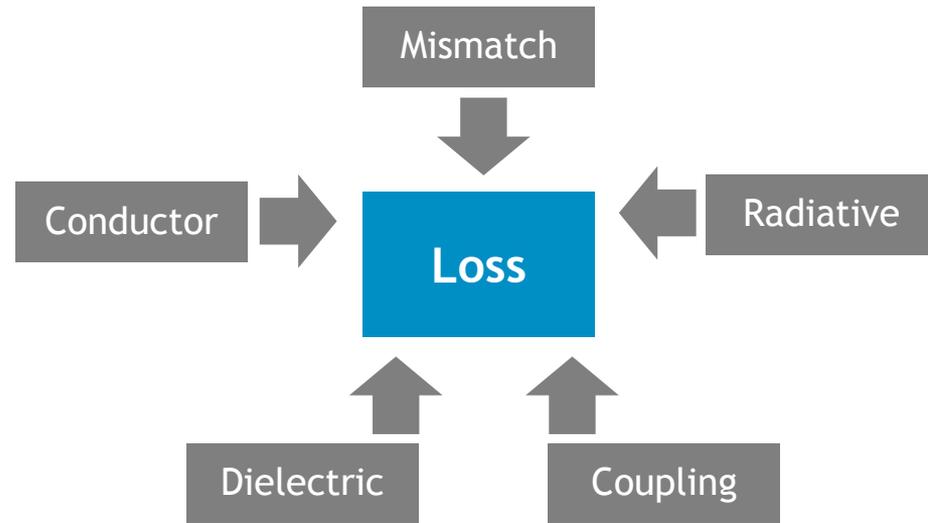

**Signal integrity simulation strategies for accurate
and fast results**
Correct Material Properties that simulate quickly

Tracey Vincent

Loss Components



Overview

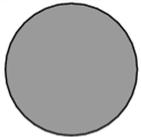
- Loss components
 - Conductor:
 - Skin effect
 - Simulating surface roughness:
 - Tabulated surface impedance: Hammerstad, Huray
 - 3D models- Periodic surface, random surface
 - DERM - Effective Dielectric method - (Dr. M. Koledintseva)
 - Edge effects: case studies
 - Dielectric :
 - Theory and parameters
 - Nth order curve fitting
 - Material properties modeling/extraction based on measured data
 - Popular Techniques
 - CST Extraction Macro
 - Two Transmission Line
 - NIST Multiline TRL
 - Discussion and conclusion

Conductor Loss

Skin Effect Theory

Current density increases at extremities at RF frequencies

Cross-sectional area of round conductor



At DC
Current density
fills cross-
section

$$R_{DC} = \frac{1}{\sigma S} \text{ ohms/meter}$$



At AC
Current density
moves toward
extremities



At GHz frequencies
Current density
concentrated at
extremities

$$R_{AC} = \frac{1}{\sigma \delta P} \text{ ohms/meter}$$
$$= \frac{R_s}{P} \text{ ohms/meter}$$

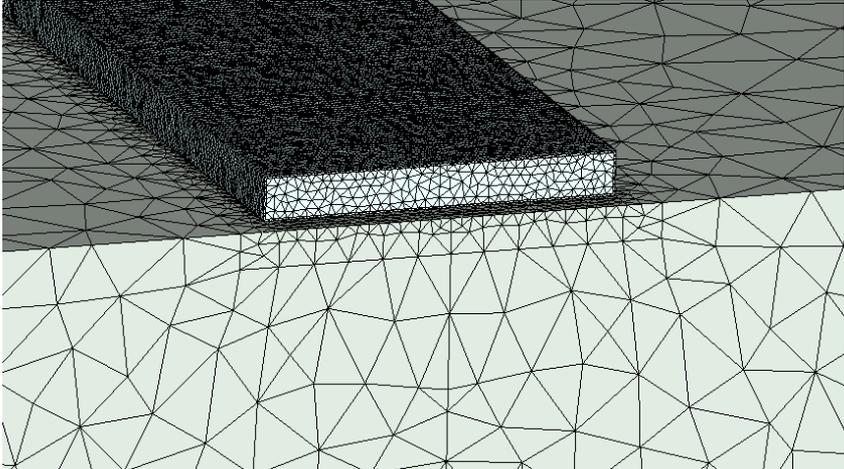
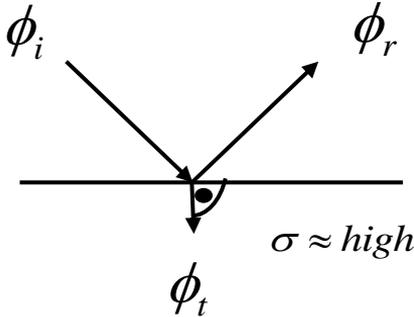
S is the cross-section area of the conductor.

σ is the volume conductivity.
Current is homogenous.

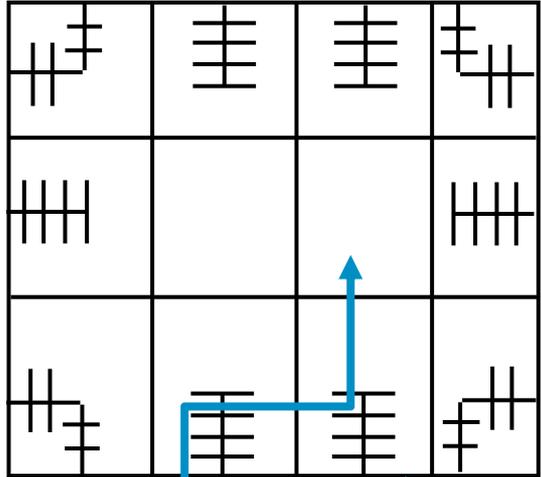
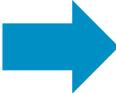
P is the *circumference* of the conductor, δ is skin depth. The δP is the equivalent cross-section area.

$$\delta = \sqrt{\left(\frac{2}{\omega \mu_0 \sigma} \right)}$$

Skin Effect - Lossy Metal



Alternative

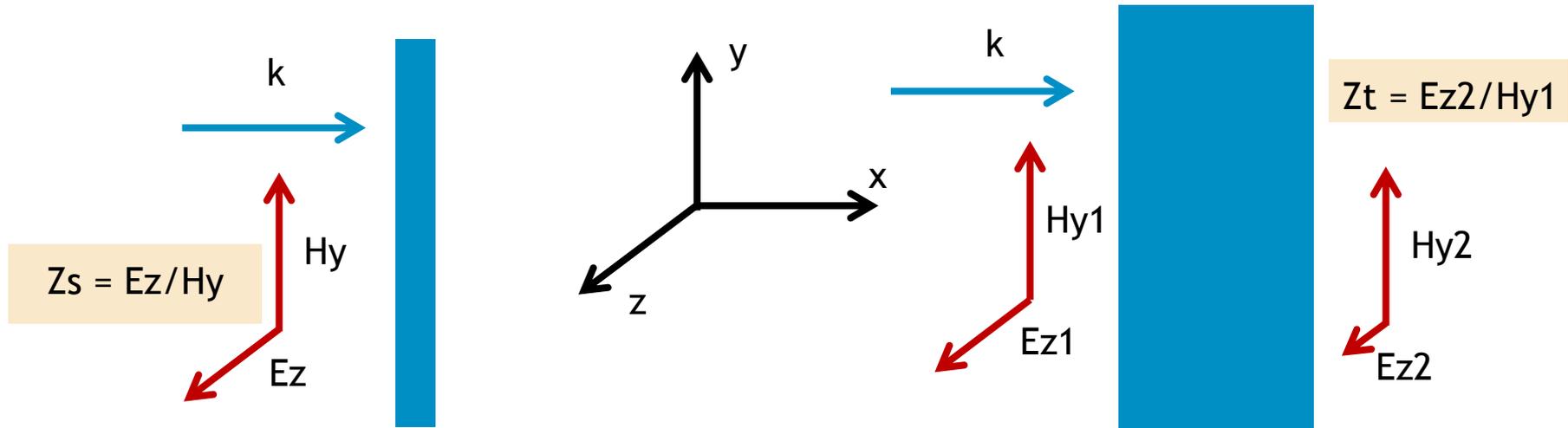


Field = 0

Surface impedance

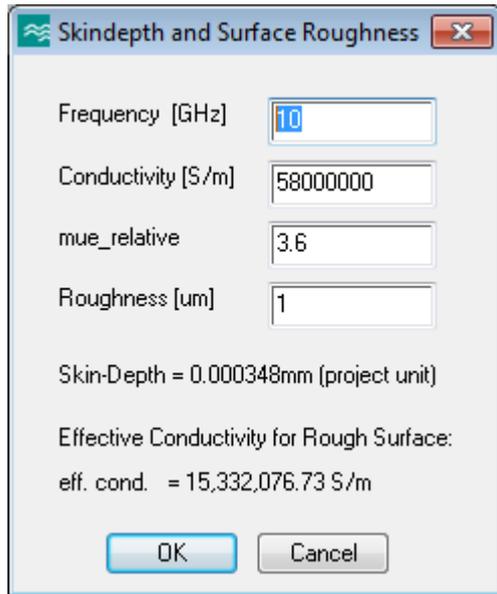
Surface Impedance Materials

- In principle, a classical dispersive material could be used
- However, an excessively fine mesh might be needed:
 - If the object made of that material is too thin
 - If the penetration depth of the field into the object is very small
- The surface impedance model is a way to avoid a very fine mesh



Surface Roughness Parameterization

Narrow band
“quick”
parameterization



Frequency [GHz]

Conductivity [S/m]

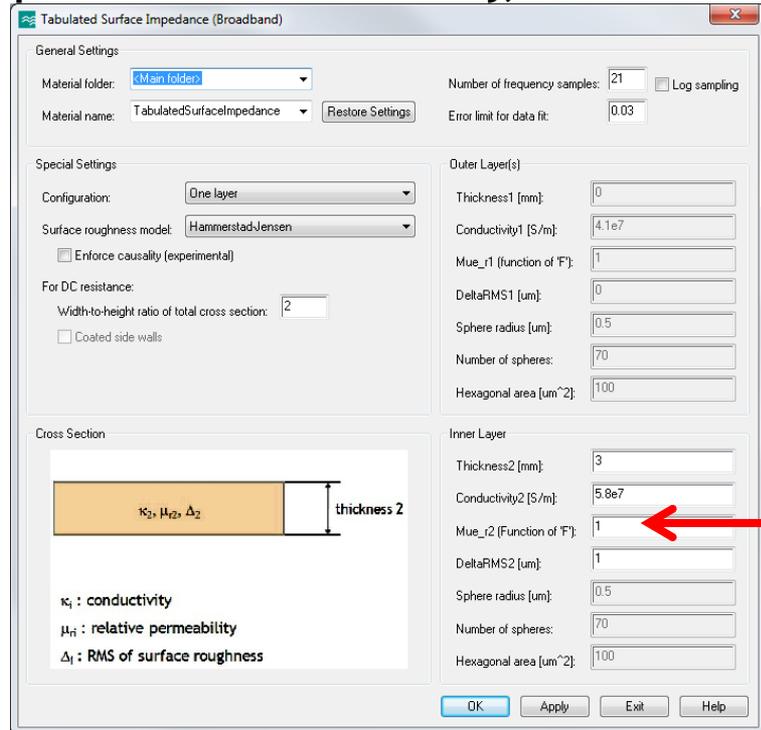
mue_relative

Roughness [um]

Skin-Depth = 0.000348mm (project unit)

Effective Conductivity for Rough Surface:
eff. cond. = 15,332,076.73 S/m

Broadband tabulated surface impedance
parameterization: Huray, Hammerstad



General Settings

Material folder:

Material name:

Number of frequency samples: Log sampling

Error limit for data fit:

Special Settings

Configuration:

Surface roughness model:

Enforce causality (experimental)

For DC resistance:

Width-to-height ratio of total cross section:

Coated side walls

Dufer Layer(s)

Thickness1 [mm]

Conductivity1 [S/m]:

Mue_r1 (function of F):

DeltaRMS1 [um]:

Sphere radius [um]:

Number of spheres:

Hexagonal area [um^2]:

Cross Section



ξ_1 , μ_{r1} , Δ_1

thickness 2

ξ_1 : conductivity
 μ_{r1} : relative permeability
 Δ_1 : RMS of surface roughness

Inner Layer

Thickness2 [mm]

Conductivity2 [S/m]:

Mue_r2 (Function of F):

DeltaRMS2 [um]:

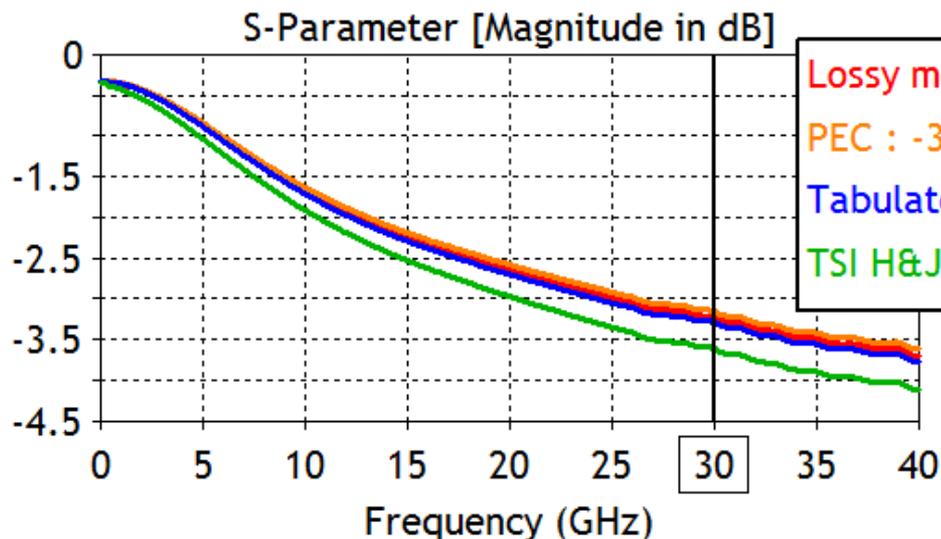
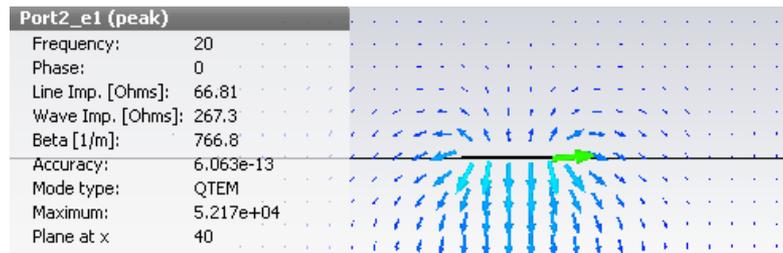
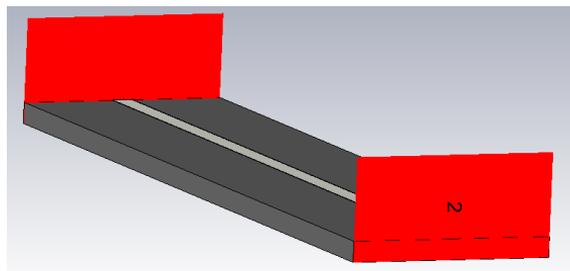
Sphere radius [um]:

Number of spheres:

Hexagonal area [um^2]:

Option to
Include
nickel

Comparison of Results for Simple Model



Lossy metal - copper 1.4e6 S/m : -3.2261569

PEC : -3.1542844

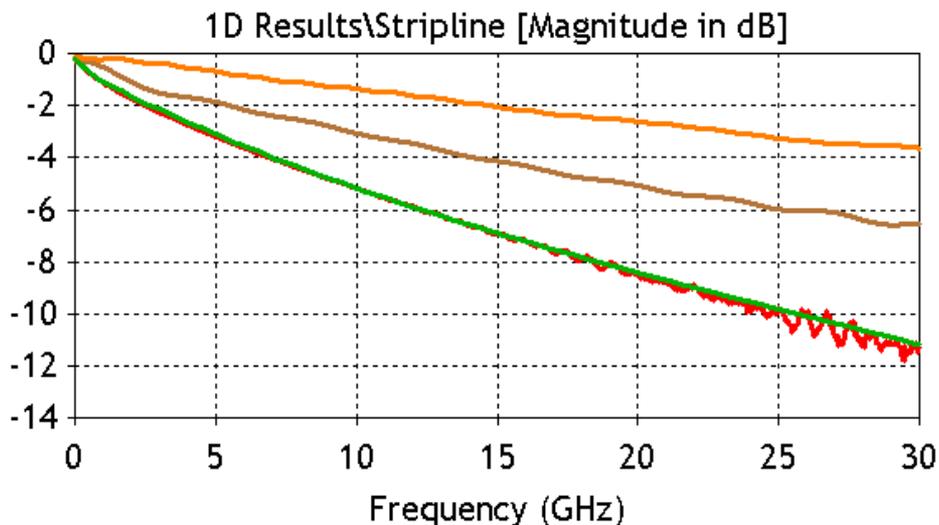
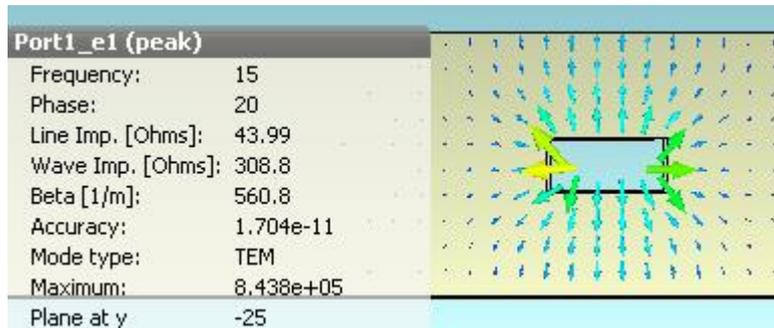
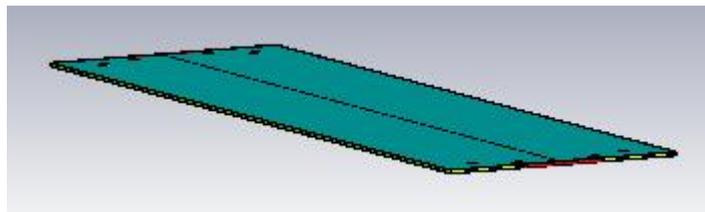
Tabulated Surface Impedance : -3.2898402

TSI H&J 2um : -3.6119272

40mm long
microstrip
model

FR4 dielectric
substrate $-\epsilon_r=4.3$,
 $\text{tg } \delta=0.025$

Measured and Simulated Data for Stripline

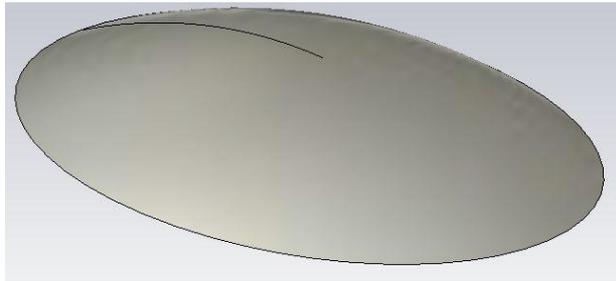


- S21 Lossy copper
- S21 Measured data
- S21 PEC
- S21 TSI H&J

FR4 dielectric substrate $\epsilon_r=3.5$, $\text{tg } \delta=0.06$

50mm long stripline model

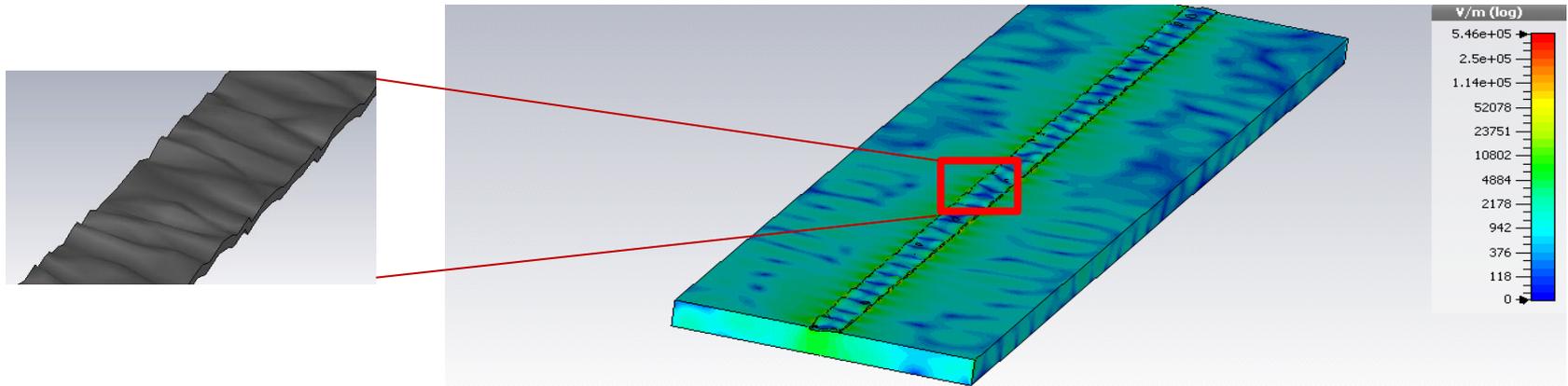
Face Distortion Surface



Create Face Distortions

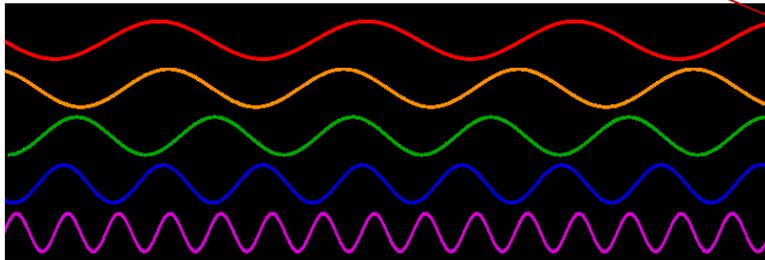
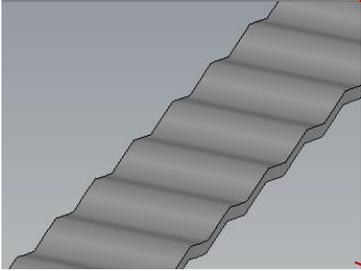


Trace generated has random distortions, specifications are: peak to peak height, average distance between peaks

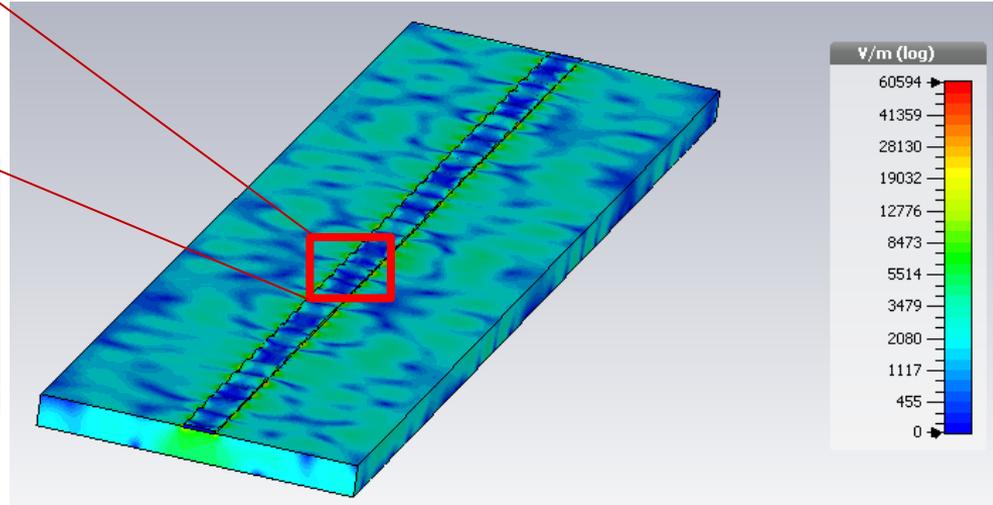


Analytical Face surface. Periodic example.

- Equation, such as polynomial can be used to generate non-smooth trace.
- Example is periodic trace: $w=Ra*\sin(b00u)$.

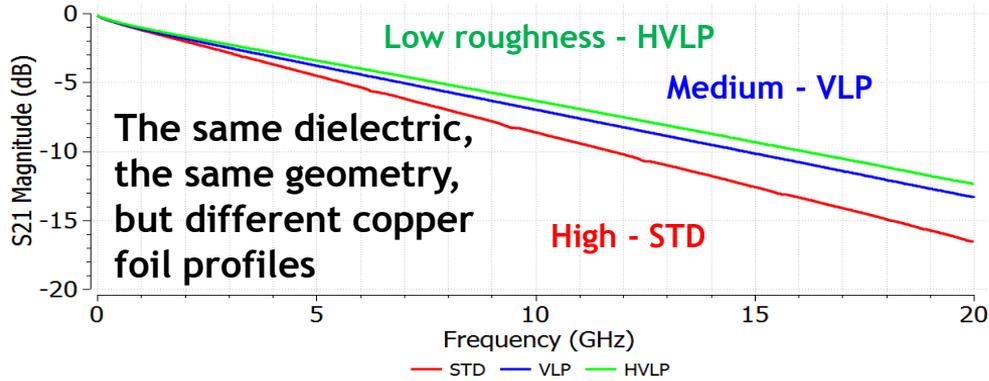


All of these waveforms have same average roughness Ra



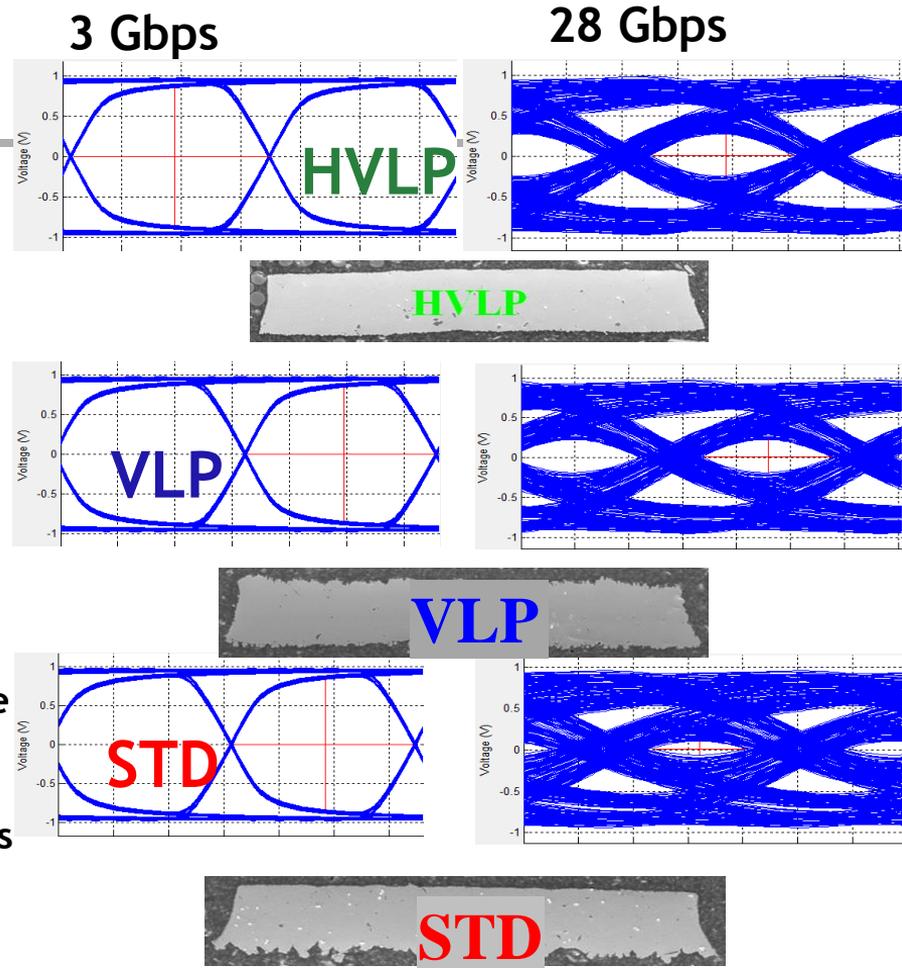
Motivation

- Conductor roughness affects both phase and loss constants in PCB transmission lines and results in eye diagram closure.



The same dielectric, the same geometry, but different copper foil profiles

- Conductor surface roughness lumps into laminate dielectric parameters.
- Surface roughness topography of printed circuit boards (PCBs) needs to be included in simulations in order to accurately predict wideband frequency behavior of designs for both SI and EMC/EMI purposes.



New Analytical Method “Roughness Dielectric”- Concept

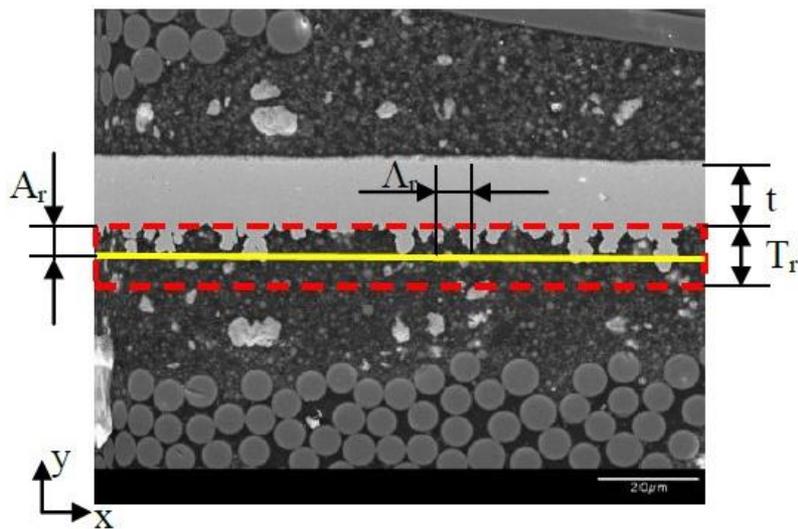


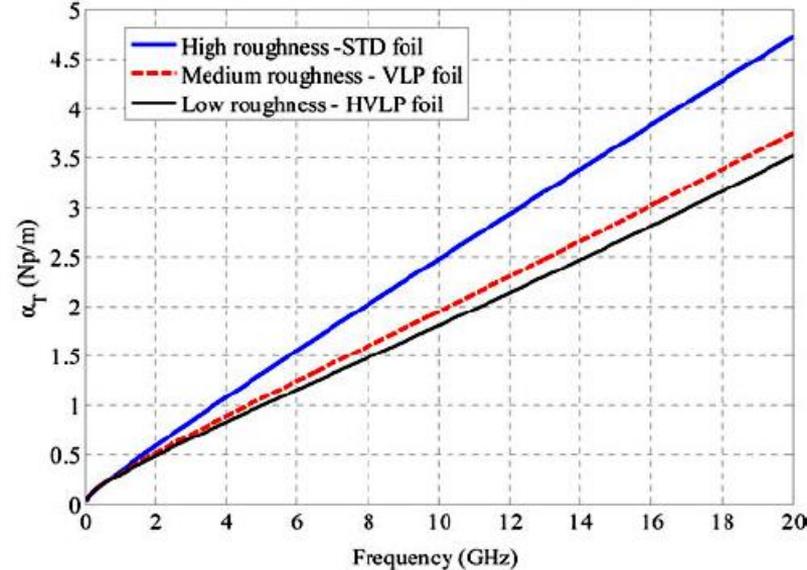
Fig. 6. Magnified section of the signal trace conductor in the SEM picture of the test line with STD foil. The region of the “roughness dielectric” is selected by a dashed line

	A_r (μm)	Λ_r (μm)	A_r/Λ_r	R_a (μm)	R_z (μm)	R_{rms} (μm)
STD	7.98	10.62	0.75	1.56	8.41	1.91
VLP	3.35	7.28	0.46	0.75	4.19	0.92
HVLP	1.65	4.69	0.35	0.35	2.29	0.44



Reference: Koledintseva, Razmadze, Gafarov, De, Drewniak, Hinaga “PCB Conductor Surface Roughness as a Layer with Effective Material Parameters” Electromagnetic Compatibility (EMC), 2012 IEEE International Symposium 2012

“Roughness Dielectric” - Extracting the parameters



Reference: Koul, Koledintseva, Hinaga, Drewniak
 “Differential Extrapolation Method for Separating Dielectric and Rough Conductor Losses in Printed Circuit Boards” IEEE Trans, 2012.

“smooth”
 conductor
 contribution
 /skin effect

Roughness
 contribution

Dielectric
 contribution

$$\alpha_T = a\sqrt{\omega} + b\sqrt{\omega} + c\omega + d\omega^2 + e\omega + f\omega^2$$

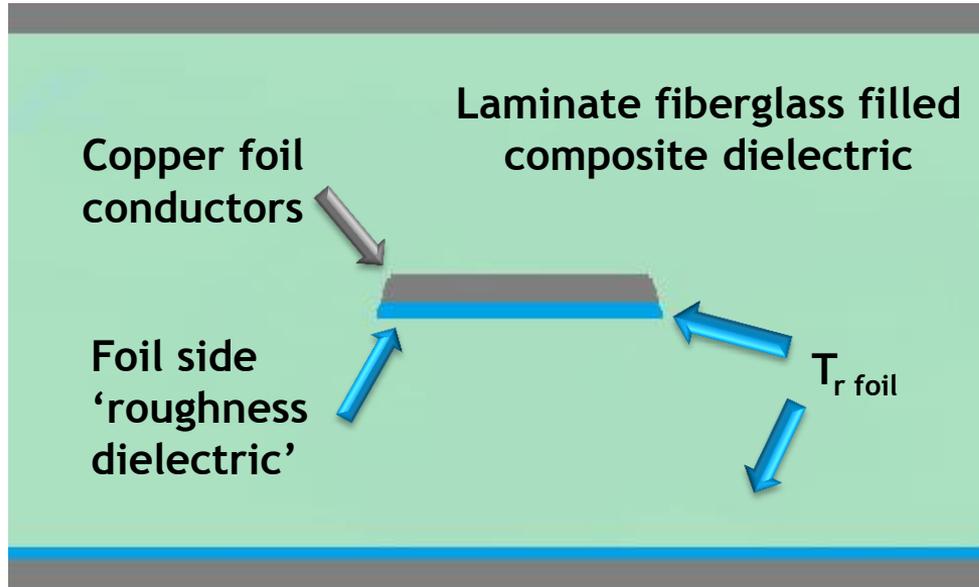
$$a + b = K1$$

$$c + e = K2$$

$$d + f = K3$$

- Curve fitting co-efficients are generated $K1 \sim \sqrt{\omega}$, $K2 \sim \omega$, and $K3 \sim \omega^2$
- $K1(0)$, $K2(0)$, and $K3(0)$ corresponds with smooth conductor, allow separation of surface roughness loss and dielectric loss. K co-efficients relate to Ar
- Dielectric material (smooth) 3D object with extracted “roughness” parameters can be included in simulation to simulate roughness impact

“Roughness Dielectric”- Concept



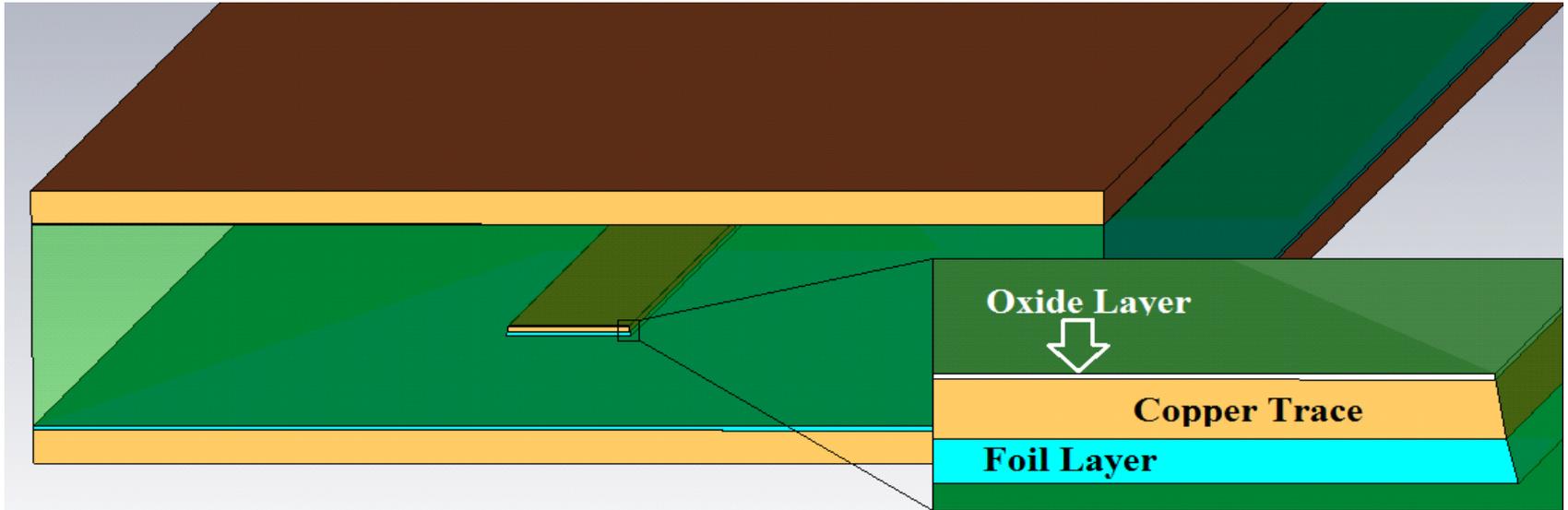
Cross section view - Not to scale for presentation purposes only

- Laminate dielectric parameters are extracted from DERM2 (for both α and β).
- Heights of ERD $T_{r \text{ foil}}$ are taken $2A_{r \text{ foil}}$, respectively.
- Line length for this model = 15,410 mils

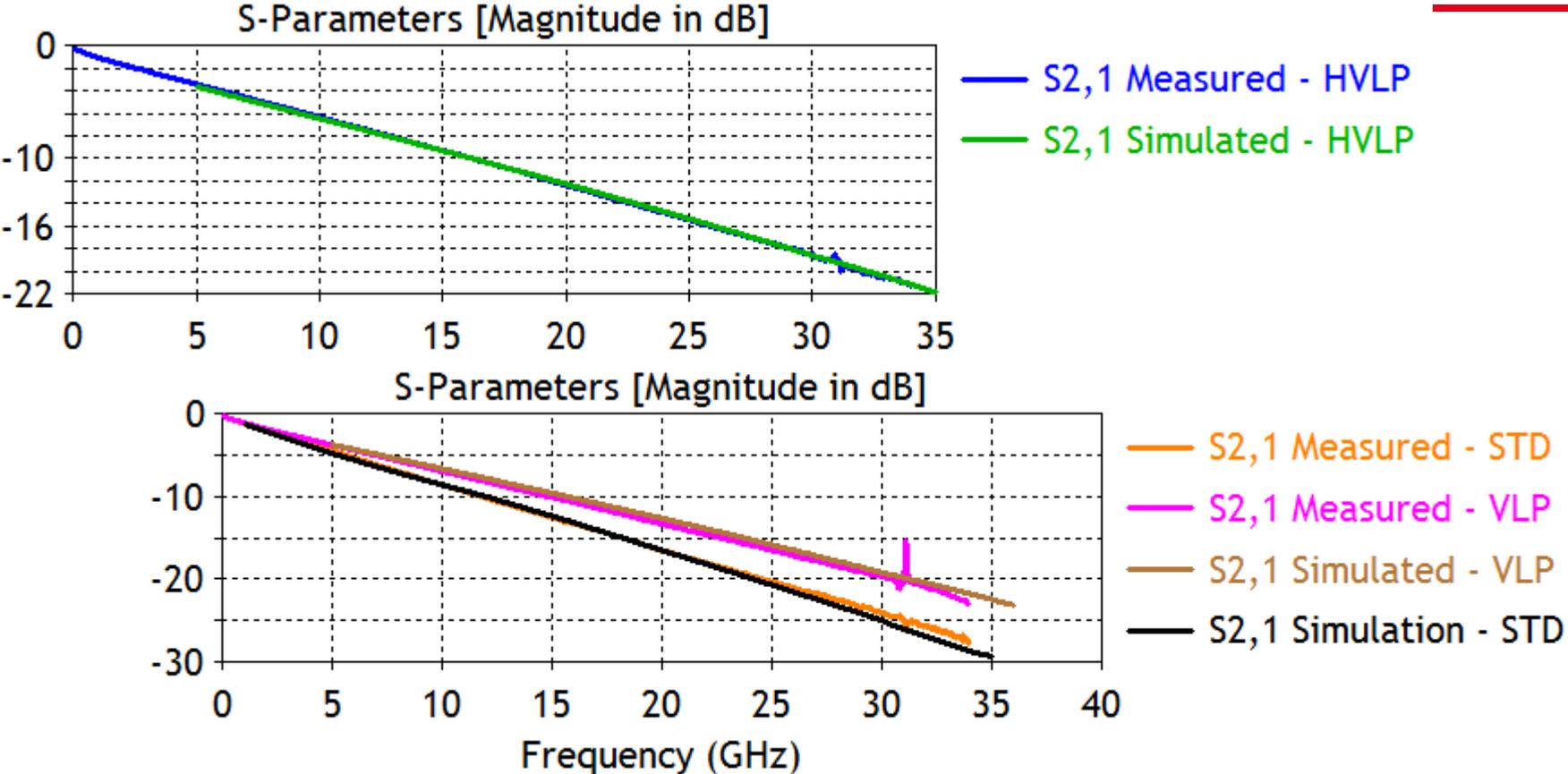


Validation Using Full-wave EM Numerical Simulations

CST Studio Suite 3D model is used for validation of the extracted ERD data



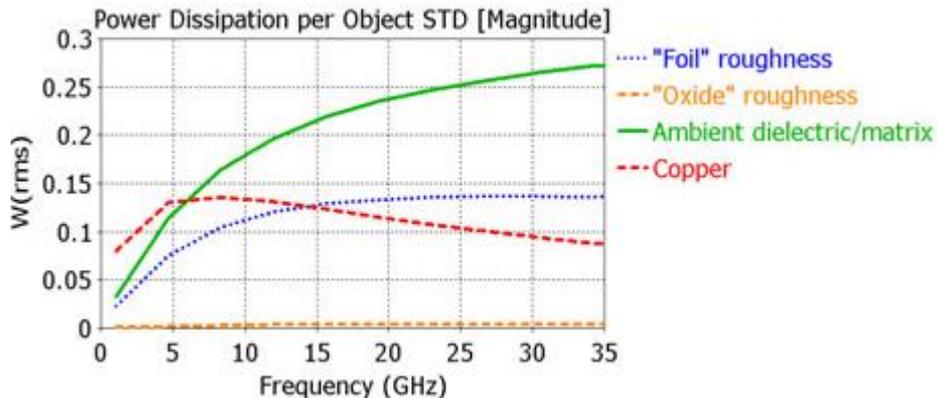
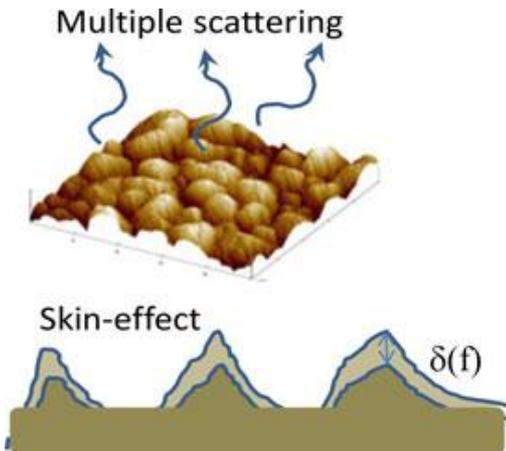
Comparison of S21 Results



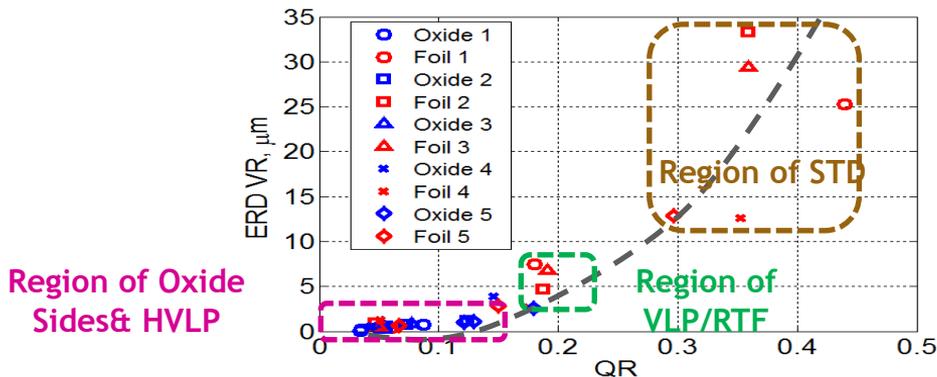
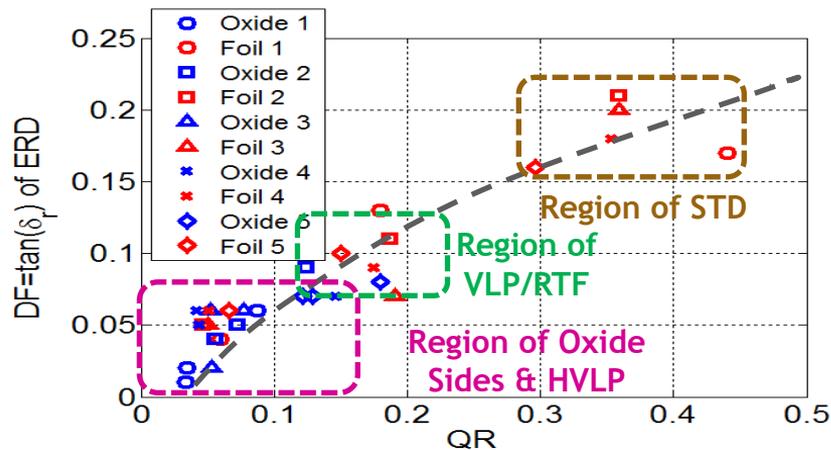
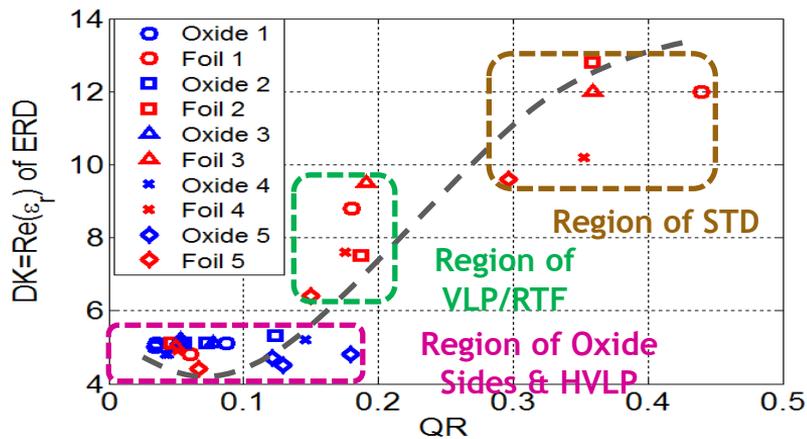
What is physically happening in the conductor foil?

Sophisticated curve fitting but what is/are the underlying physics?

- Skin effect allows field to penetrate the foil at lower band. Multiple scattering pushes the fields out of the metallic “particles” causing a slight decrease in metal loss at higher band.
- <6GHz conductor loss dominates. >6GHz dielectric loss dominates -for STD “foil” roughness is significant (not for others!)



“Design Curves” - ERD Parameters as Functions of Roughness Factor

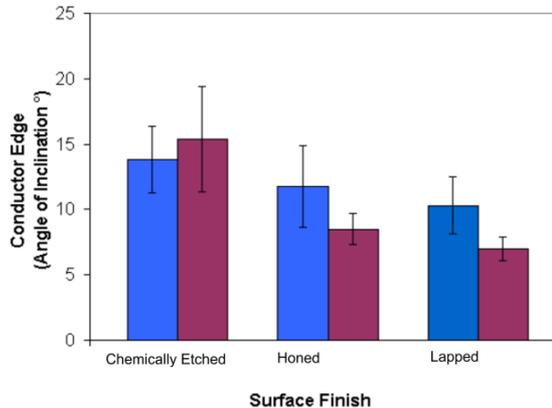
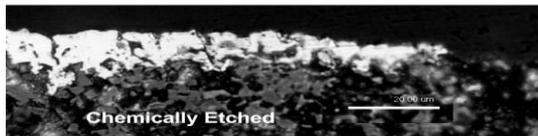
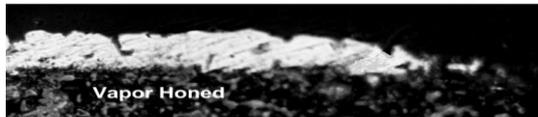
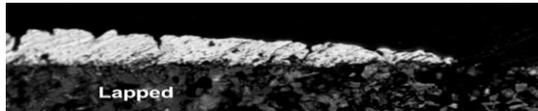
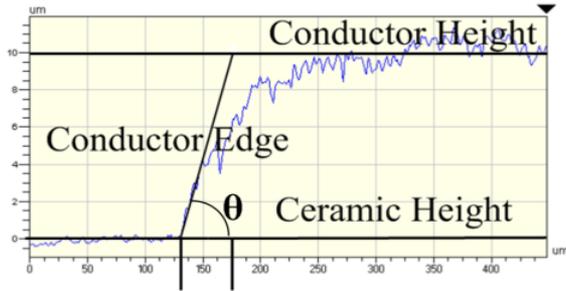


Sets 1,2,3 - 13mil trace width

Sets 4, 5 - 7 mil trace width

Trace Edge Cross-Section

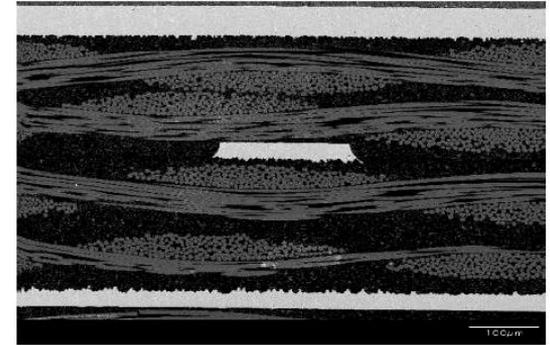
Thick-film print cross-section



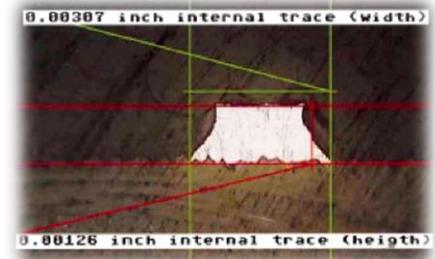
Thick film printed circuit have very sharp edges 7-15 degrees.

Results shown for 2 types of silver paste on 3 surfaces

Typical PCB cross-section



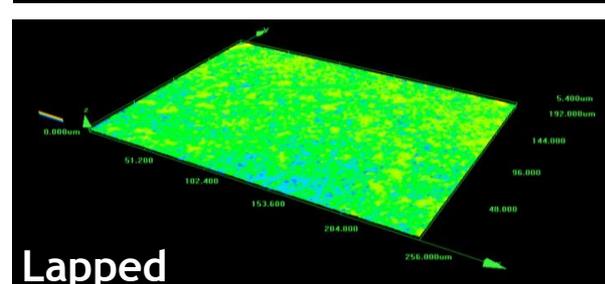
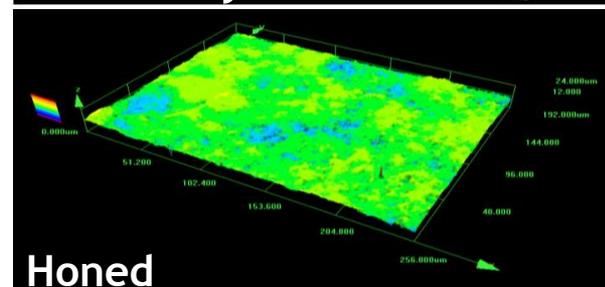
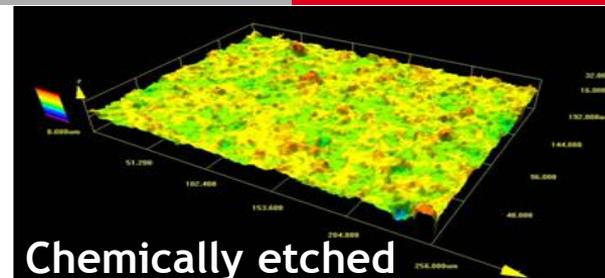
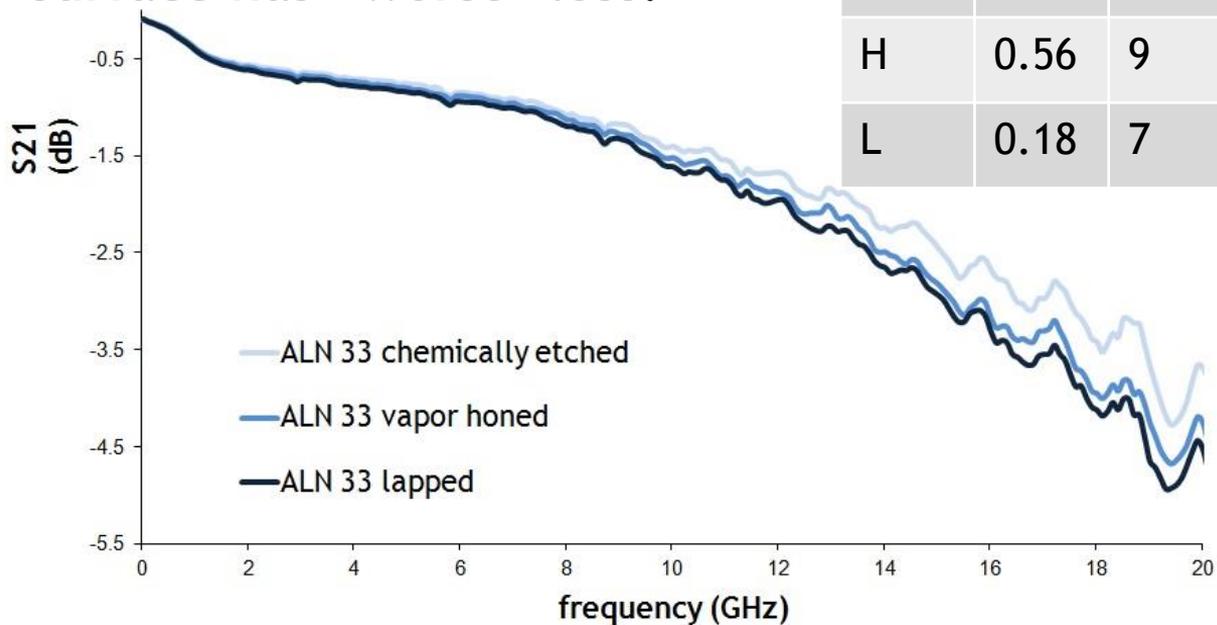
Etched circuits can have tapered edges ~45 degrees



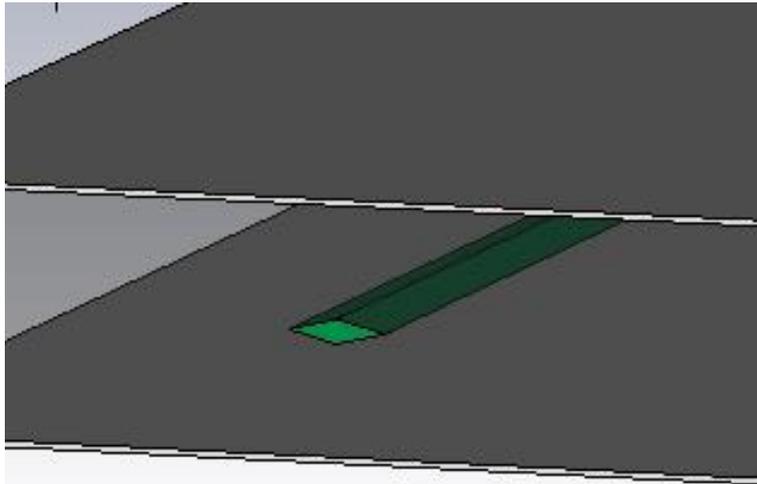
Measured Results with Sharp Edges (Printed)

“roughest” surface has
“best” loss, “smoothest”
surface has “worst” loss.

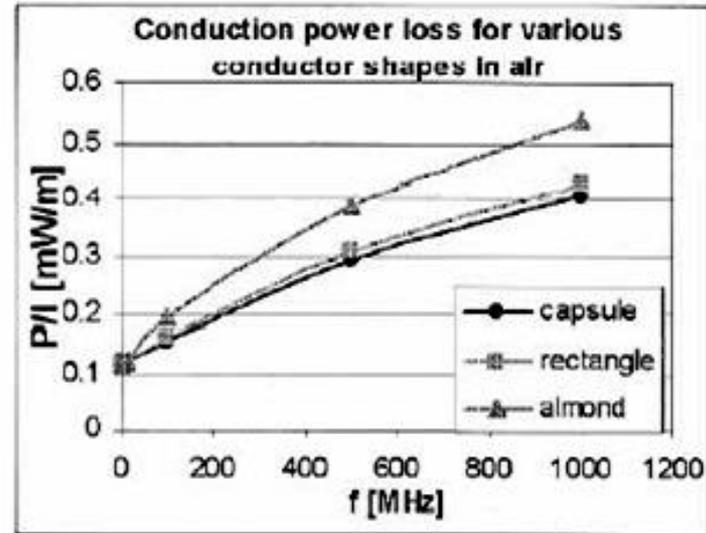
	Ra um	A°
CE	1.09	15
H	0.56	9
L	0.18	7



Edge Effect - “Almond Shape” vs Rectangular

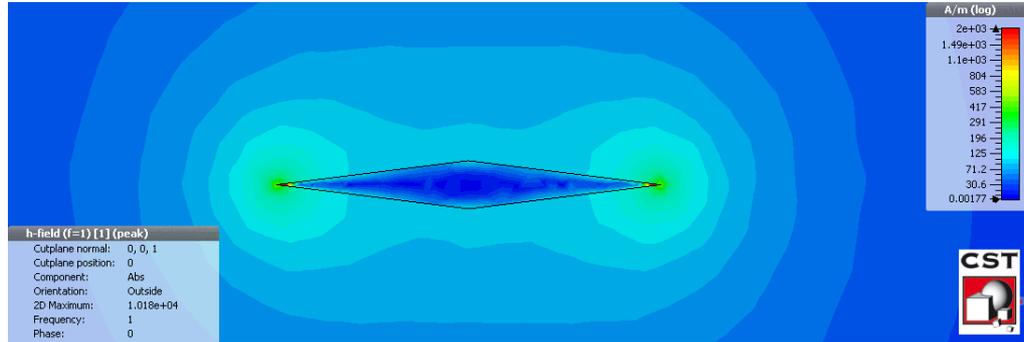


Reference: Lim, Wyk “Impact of Conductor Cross-Sectional Shape on Component Performance and Total Losses in a Microsystem” iMAPS 2006, demonstrated the increase in loss with simulated and measured conductor shapes in LTCC stripline topology



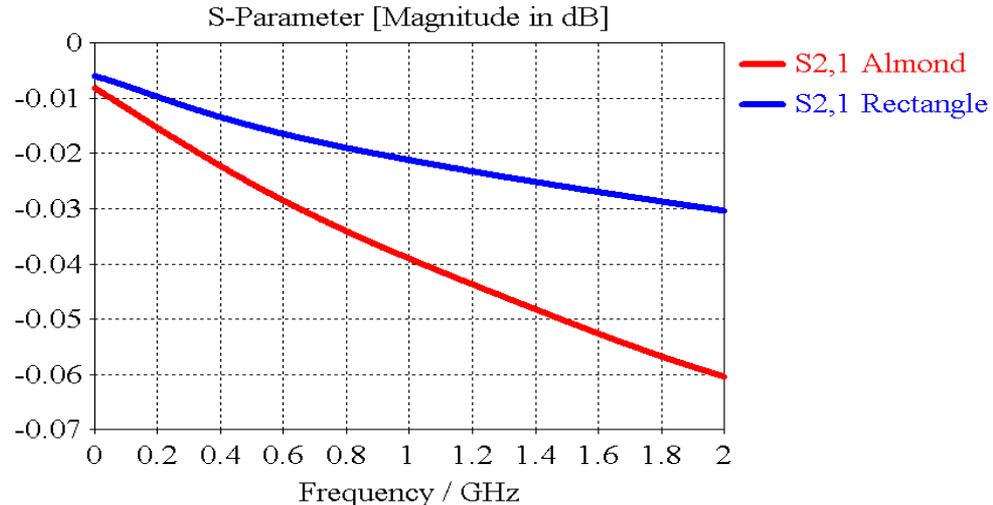
Power loss results comparing “Almond” and “Rectangle” shape with same cross-sectional area. Larger loss with “Almond” shape @ 1GHz, difference of ~38% conductor loss

Sharp Edges

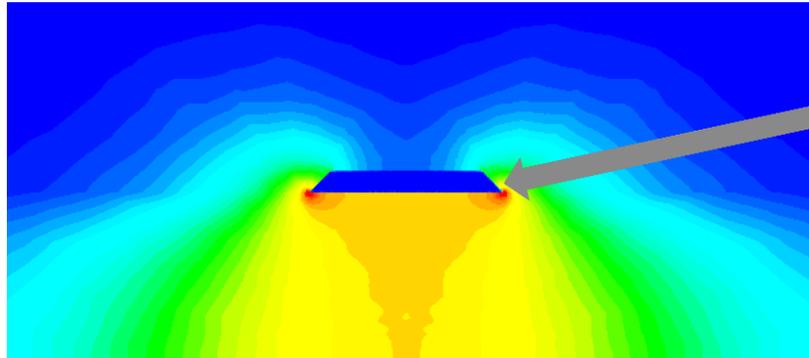


Field lines showing much stronger field at edges

$S(2,1)$ results comparing “Almond” and “Rectangle” shape with same cross-sectional area larger loss with “Almond” shape @ 1GHz



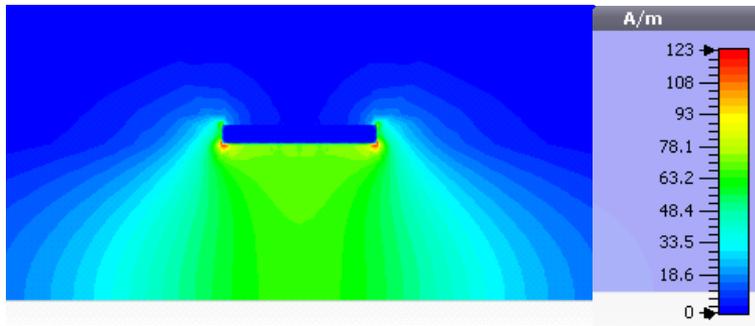
Trapezoidal Edge



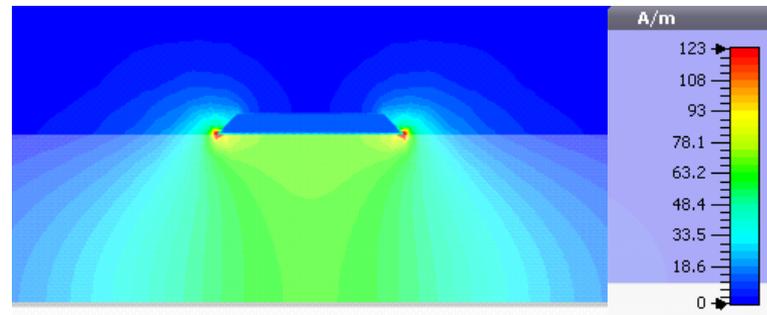
Increased peak H field at edges of trapezoidal shape

Reference: Guo, Glisson, Kajfez "Skin-effect Resistance of Conductors with a Trapezoidal Cross Section" Microwave and Optical Technology Letters, Vol. 18, No. 6, 1998.

Analytical method* to predict the resistance of trapezoidal lines. For 45 degree taper $R_{ac}/R_{ac-trap}=1.14$ @1GHz, 1.22 @50GHz



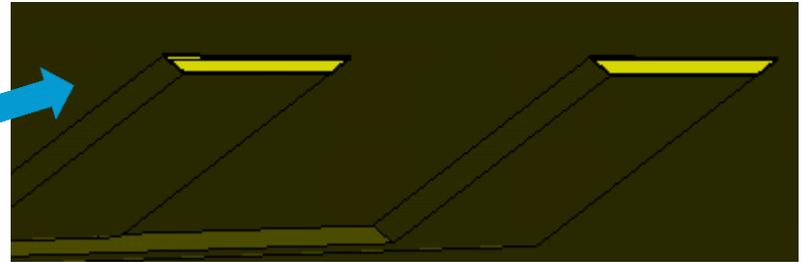
Attenuation coefficient=0.5163
@50GHz



Attenuation coefficient=0.8979
@50GHz

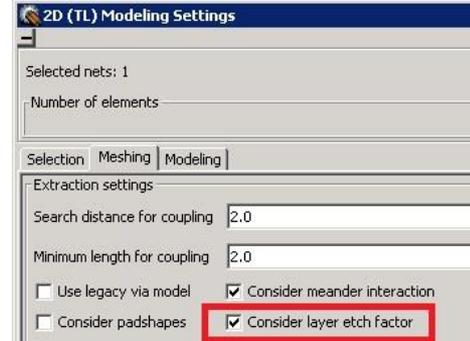
Simulation of Etch Factor

Material	Cond. / tan delta	Permittivity	Thickness	Elevation	Filling from	Etch undercut	Etch factor
COPPER	4.159e+07	0	2.9	147.4	above	bottom	0.8
FR-4	0.01@10GHz	3.6	4.2	143.2			
COPPER	4.159e+07	0	0.6	142.6	above	bottom	0.8
FR-4	0.01@10GHz	3.6	6	136.6			
COPPER	4.159e+07	0	0.9	135.7	above	bottom	0.8
FR-4	0.01@10GHz	3.6	9	126.7			
COPPER	4.159e+07	0	0.6	126.1	above	bottom	0.8
FR-4	0.01@10GHz	3.6	6	120.1			
COPPER	4.159e+07	0	0.6	119.5	above	bottom	0.8
FR-4	0.01@10GHz	3.6	9	110.5			
COPPER	4.159e+07	0	0.6	109.9	above	bottom	0.8
FR-4	0.01@10GHz	3.6	6	103.9			
COPPER	4.159e+07	0	0.6	103.3	above	bottom	0.8
FR-4	0.01@10GHz	3.6	9	94.3			
COPPER	4.159e+07	0	0.6	93.7	above	bottom	0.8
FR-4	0.01@10GHz	3.6	6	87.7			



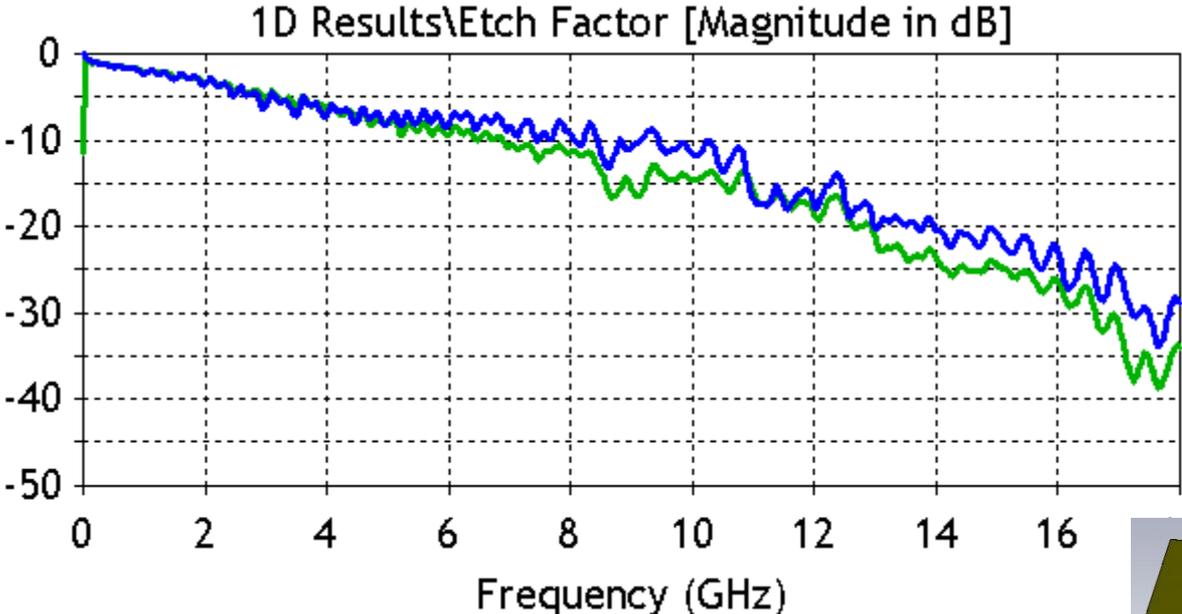
CST
MICROWAVE
STUDIO

Etch factor implemented on import
of EDA file

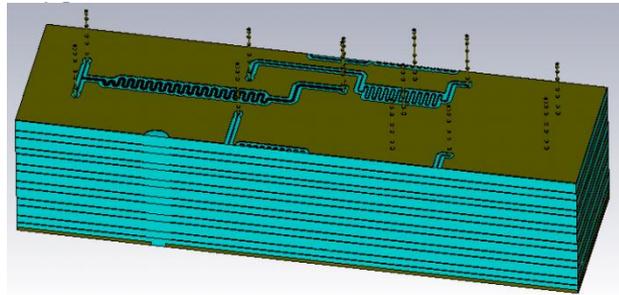


CST
PCB
STUDIO

Etch Factor



— S_{2,1} Etch Factor 0.8
— S_{2,1} Rectangle



A couple of notes before moving on....

Bulk conductivity:

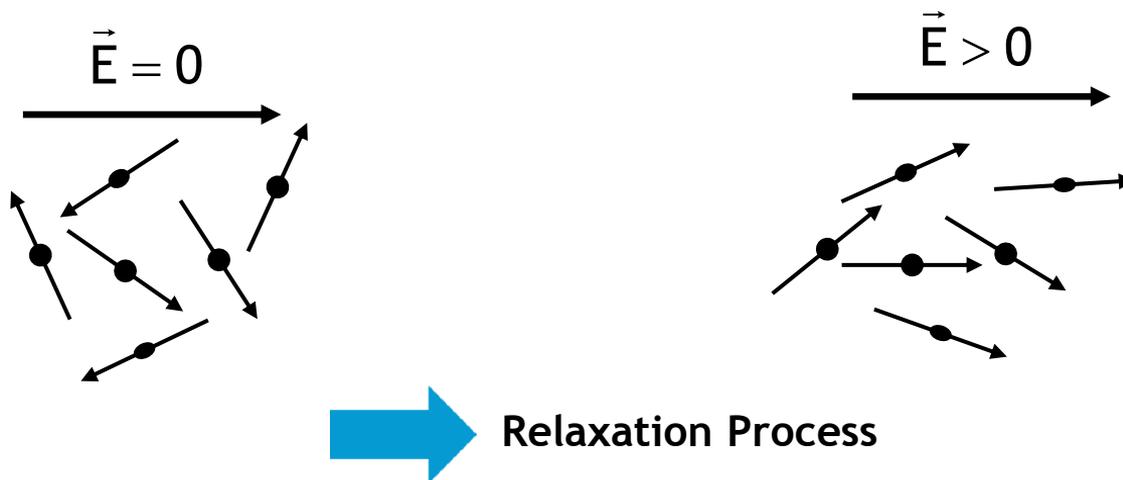
- Is the conductivity of the metal correct? Any slight alloying will drastically reduce the conductivity.
- Good news - bulk conductivity can, fairly easily, be tested.

Nickel:

- Nickel can be mechanically desirable. The material characteristics of nickel can also be included in the TSI
- For example: $1+16*\exp(-F2/15)$ [Hodsman, Eichholz, and Millership]
[Design Con 2012, EM modeling of Board Surface Finish Effect on High-Speed PCB Performance, Yuming, Scharf]

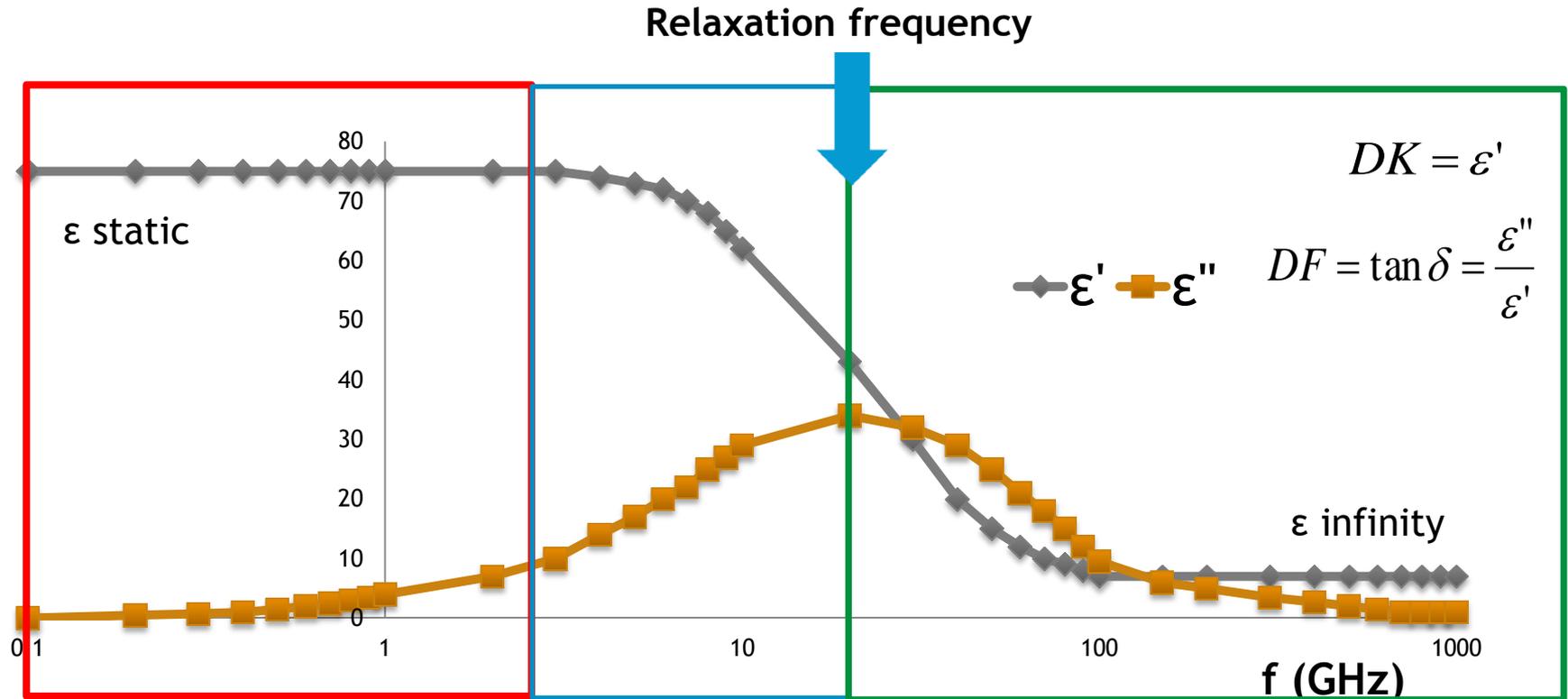
Dielectric Loss

Dielectric Material Theory



- Such dielectric behavior can be modeled by including many relaxation terms, each localized around different frequency.
- Common PCB/package dielectric materials exhibit gradual change in dielectric constant over a very broadband frequency range.

Dielectric Loss Theory - 1st Order Debye Dispersion



Dielectric Loss - Causality

Definition: in any passive circuit, the effect always has to follow the cause.



“The man who shoots faster than his shadow“

Or

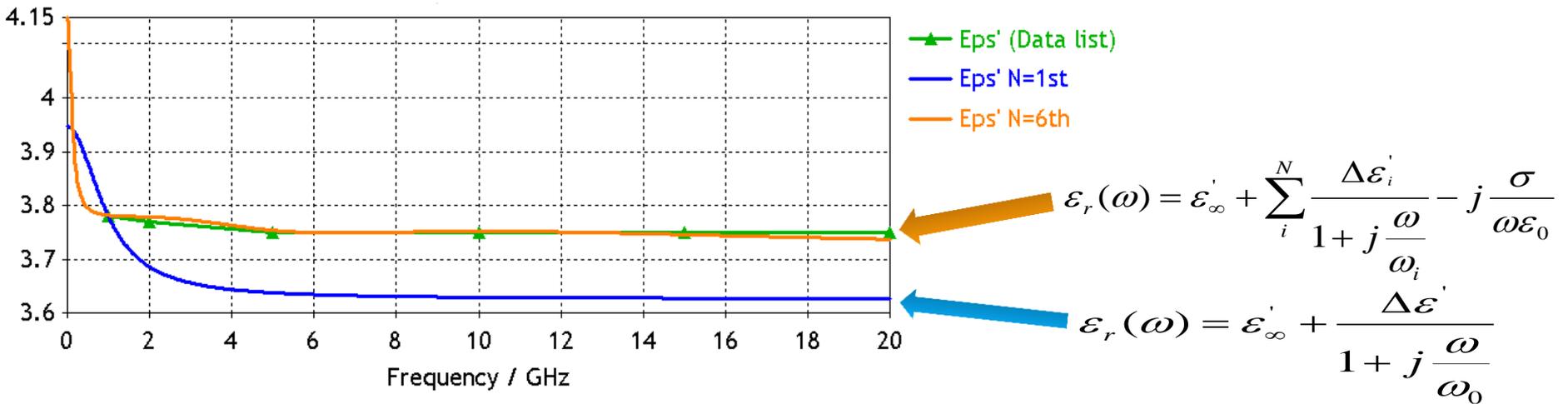
“The shadow shoots the man“!

Sources of non-causality: Measurement, simulation (resonance, round error, interpolation, and extrapolation), and data manipulation.

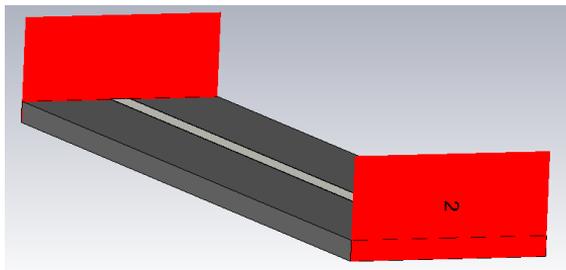
Time domain solvers are broadband, curve fitting will retain causality.

Dielectric Loss - Curve fitting Nth Orders

- Why nth order?
 - The transient solver is broadband (often more broadband than device modeled), dispersive materials: fit required.
 - nth order Debye/Lorentz fit more accurately than simple Debye or Lorentz models.

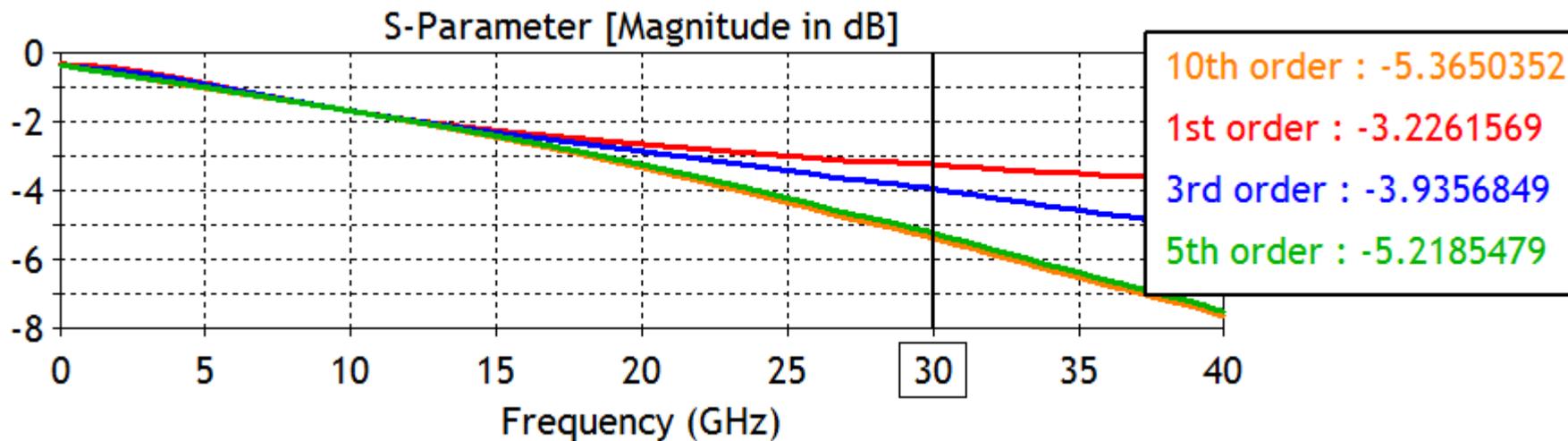


Curve Fitting Comparison - S21 Results

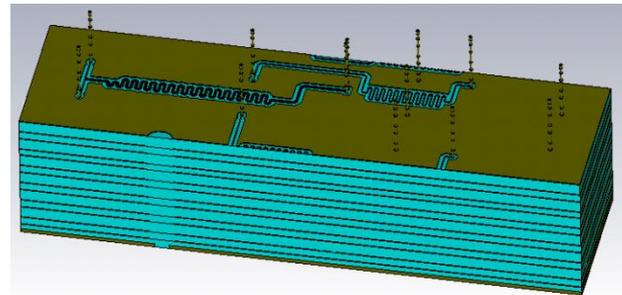
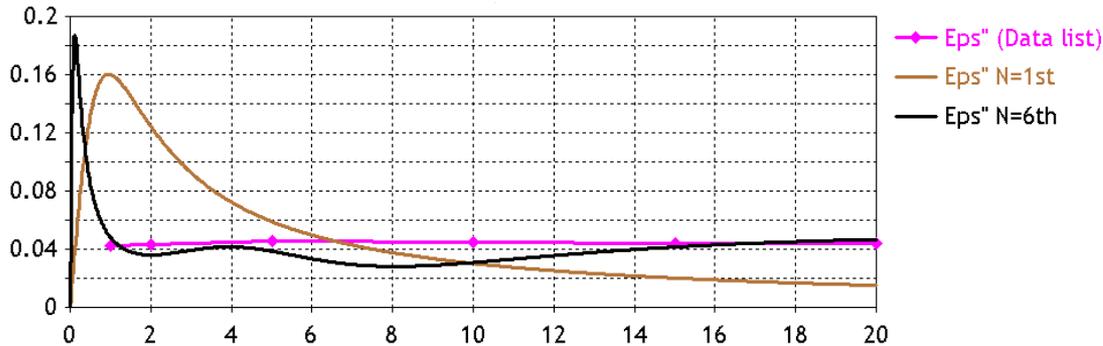
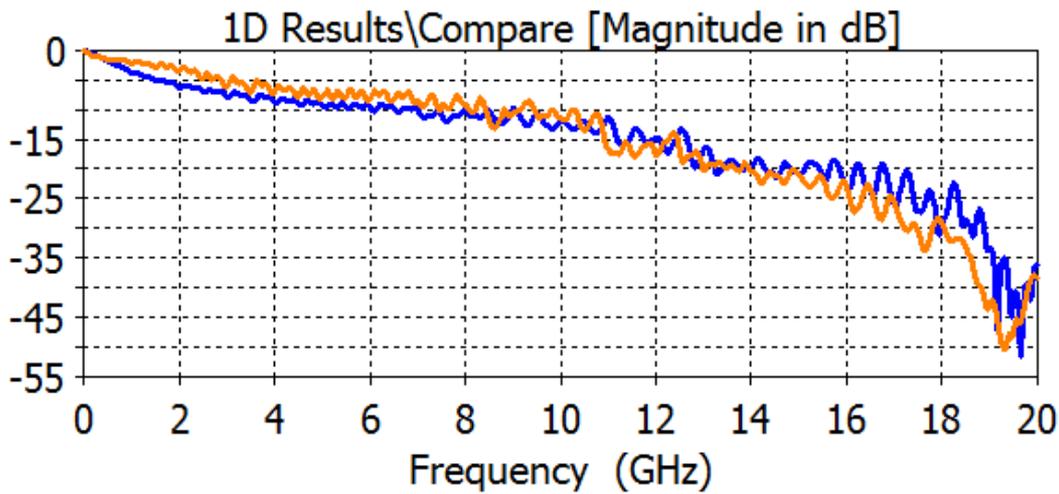


40mm long
microstrip
model

FR4 dielectric
substrate $-\epsilon_r=4.3$,
 $\text{tg } \delta=0.025$



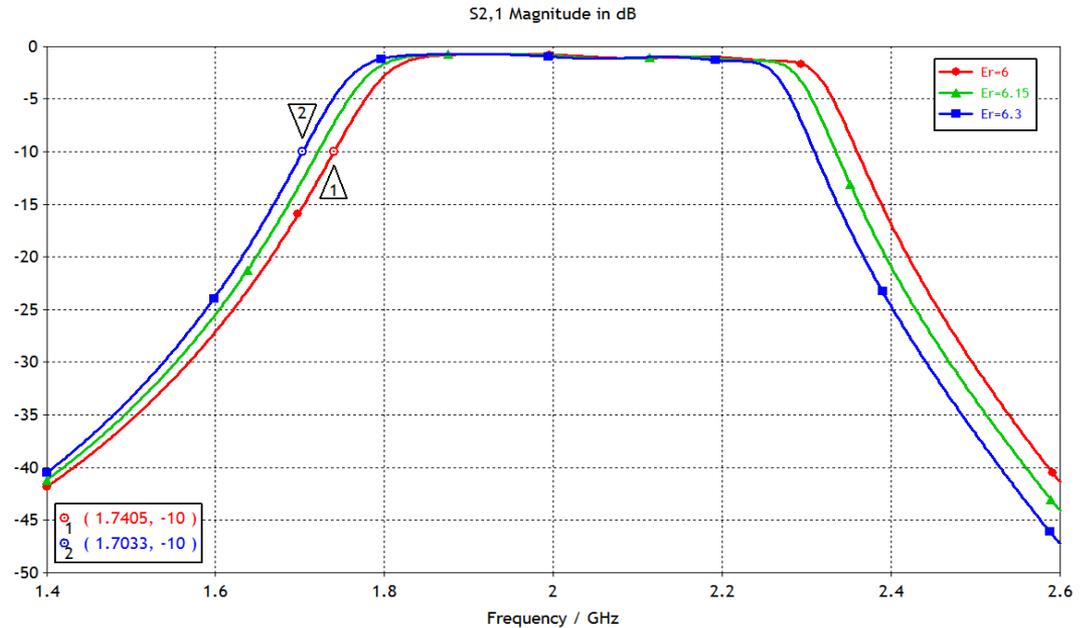
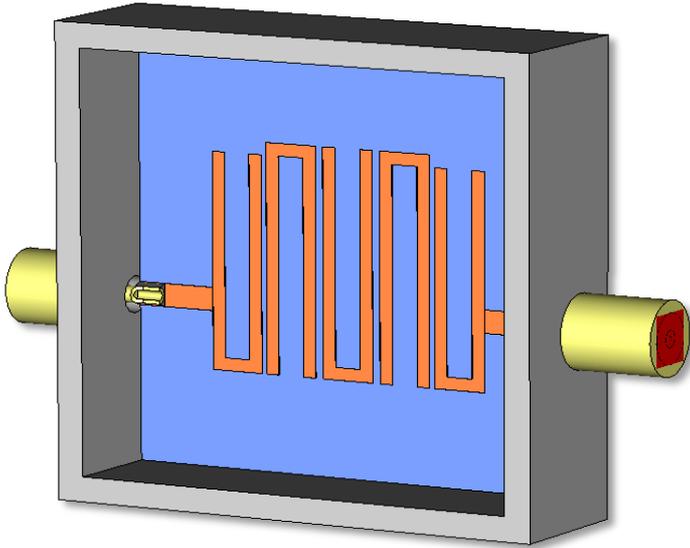
Dielectric Loss - Curve Fitting Nth Orders - S21 Results



Dielectric material parameters extraction

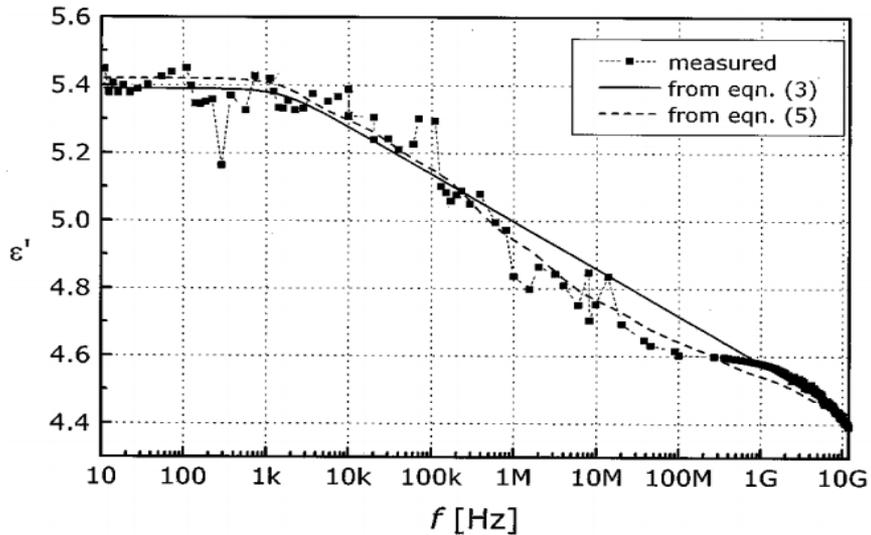
Material Properties

Uncertainty in ϵ_r ...

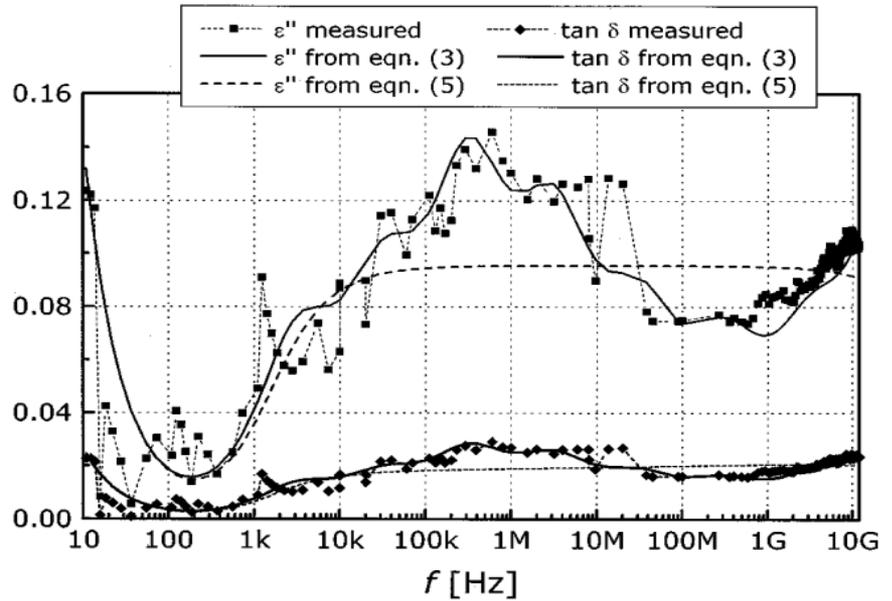


Material Properties

Uncertainty in dispersion of ϵ_r ...



“FR-4”?

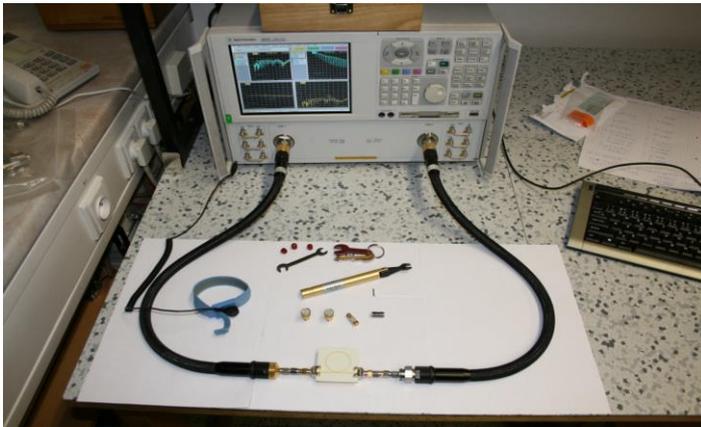


Where can I find properties?

- Datasheet
- Literature
- **Measurement!**

RO4000® Series High Frequency Circuit Materials

Property	Typical Value		Direction	Units	Condition	Test Method
	RO4003C	RO4350B				
Dielectric Constant, ϵ_r (Process specification)	3.38 ± 0.05	⁽¹⁾ 3.48 ± 0.05	Z	--	10 GHz/23°C	IPC-TM-650 2.5.5.5 ⁽²⁾ Clamped Stripline
⁽³⁾ Dielectric Constant, ϵ_r (Recommended for use in circuit design)	3.55	3.66	Z	--	FSR/23°C	IPC-TM-650 2.5.5.6 Full Sheet Resonance
Dissipation Factor tan, δ	0.0027 0.0021	0.0037 0.0031	Z	--	10 GHz/23°C 2.5 GHz/23°C	IPC-TM-650 2.5.5.5



Wideband Frequency-Domain Characterization of FR-4 and Time-Domain Causality

Antonije R. Djordjević, Radivoje M. Biljić,
Vladana D. Likar-Smiljanić, and Tapan K. Sarkar

Abstract—FR-4 is one of the most widely used dielectric substrates in the fabrication of printed circuits for fast digital devices. This material exhibits substantial losses and the loss tangent is practically constant over a wide band of frequencies. This paper presents measured data for the complex permittivity of this material from power frequencies up to the microwave region. In addition it gives simple closed-form expressions that approximate the measured data and provide a causal response in the time domain.

Index Terms—Causality, dielectric losses, dielectric measurements, dispersive media.

Popular Techniques for dielectric materials extraction

Overview of various techniques

- Full Sheet Resonance (FSR) - only ϵ_s , low freq. < 1 GHz
- Clamped Stripline Resonator - ϵ_s can be reported lower, moderate acc. for tgD
- Split Post Dielectric Resonator (SPDR) - sensitive to sample thickness, ϵ_s only
- “RA” resonator - Anisotropic permittivity, ϵ_s only, fixture freq. limit

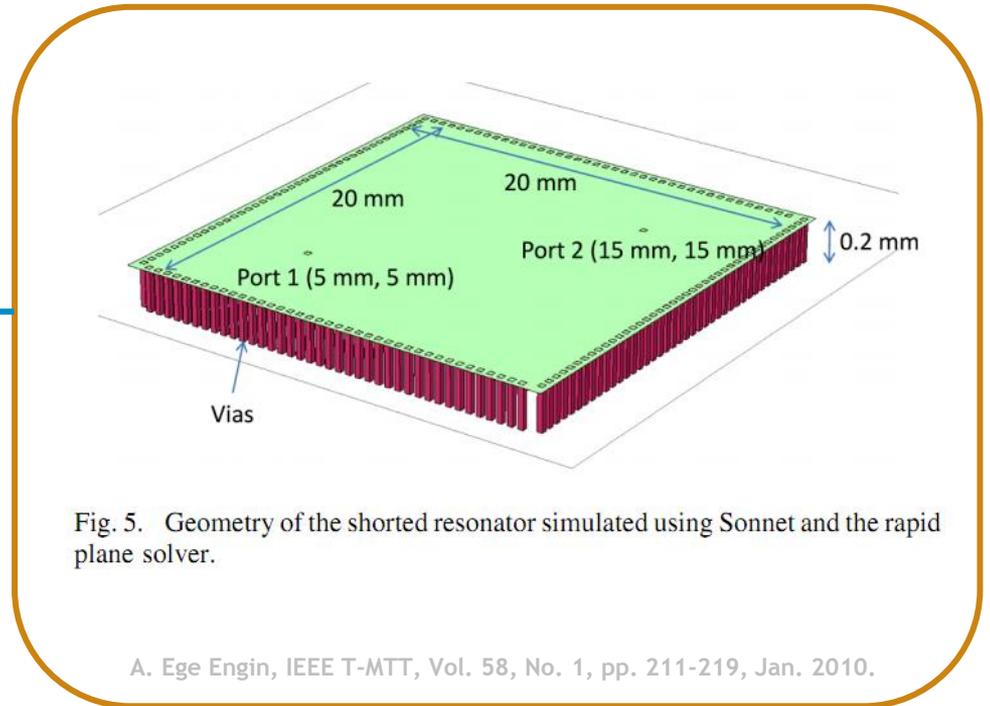
- **Cavity resonator** - freq. limit, probe influence
- **Ring resonator** - only ϵ_s

focus of this presentation

- **Modified ring resonator** - probe influence on tgD
- **Transmission line propagation constant** - ϵ_s and tgD, probe influence eliminated, very wide frequency range, moderate accuracy for tgD at low freq.

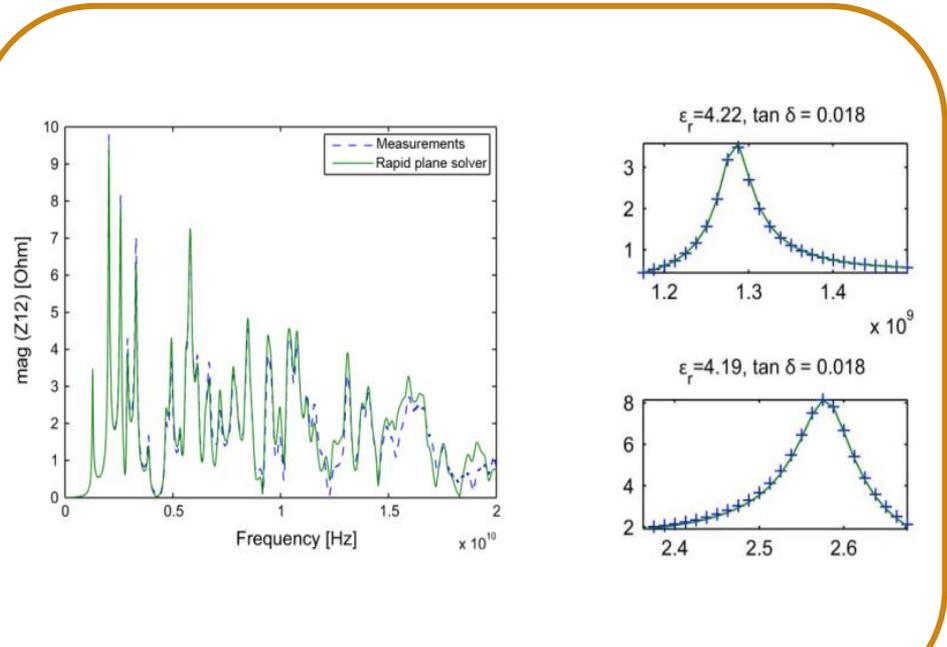
Overview

- Full Sheet Resonance
- Clamped Stripline Resonator
- Split Post Dielectric Resonator
- “RA” resonator
- **Cavity resonator**
- **Ring resonator**
- **Modified ring resonator**
- **Transmission Line (TL)**



Overview

- Full Sheet Resonance
- Clamped Stripline Resonator
- Split Post Dielectric Resonator
- “RA” resonator
- **Cavity resonator**
- **Ring resonator**
- Modified ring resonator
- Transmission Line (TL)



A. Ege Engin, IEEE T-MTT, Vol. 58, No. 1, pp. 211-219, Jan. 2010.

Overview

- Full Sheet Resonance
- Clamped Stripline Resonator
- Split Post Dielectric Resonator
- “RA” resonator
- Cavity resonator
- **Ring resonator**
- Modified ring resonator
- Transmission Line (TL)

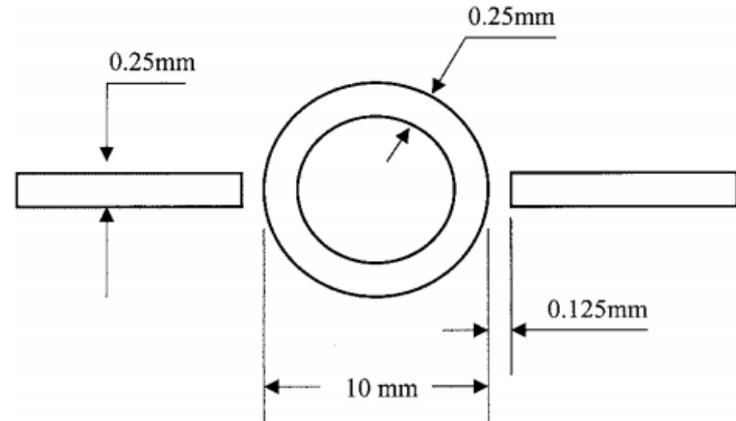
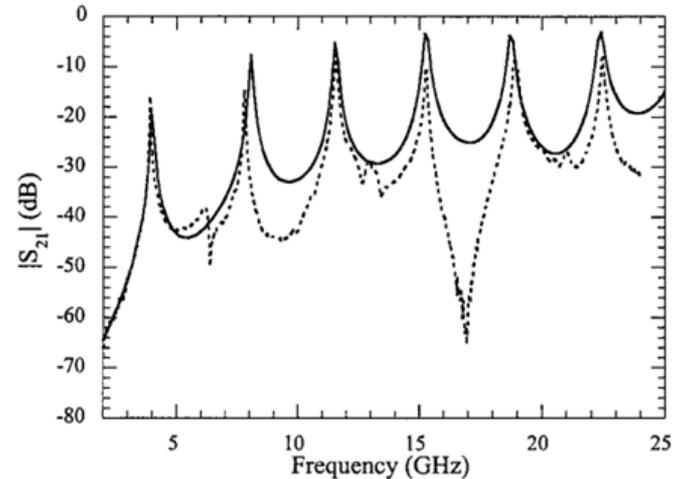


Figure 1 Ring resonator geometry

Semouchkina et al., MOT Lett., Vol. 29, No. 1, pp. 21-24, Apr. 2001.

Overview

- Full Sheet Resonance
- Clamped Stripline Resonator
- Split Post Dielectric Resonator
- “RA” resonator
- Cavity resonator
- Ring resonator
- Modified ring resonator
- Transmission Line (TL)



Semouchkina et al., MOT Lett., Vol. 29, No. 1, pp. 21-24, Apr. 2001.

Overview

- Full Sheet Resonance
- Clamped Stripline Resonator
- Split Post Dielectric Resonator
- “RA” resonator

- Cavity resonator
- Ring resonator

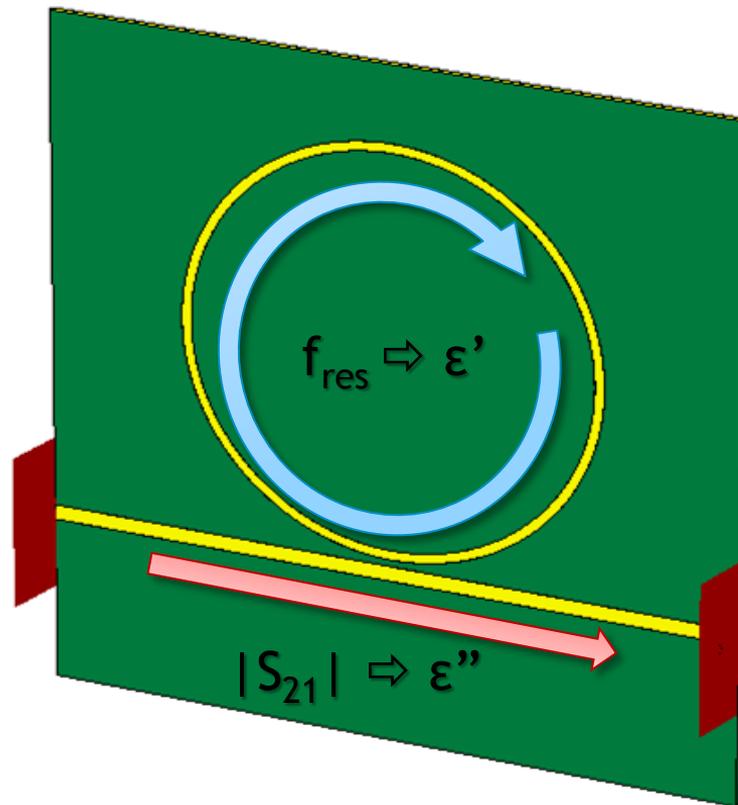
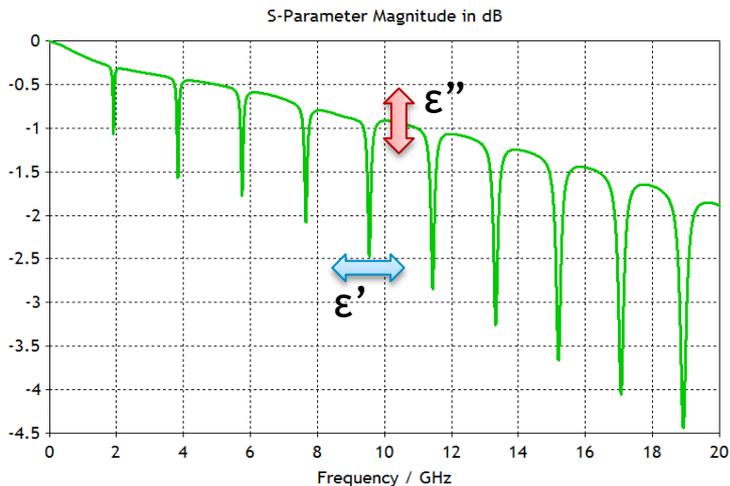
- Modified ring resonator
- Transmission Line (TL)

Modified Ring Resonator

- Parallel coupling

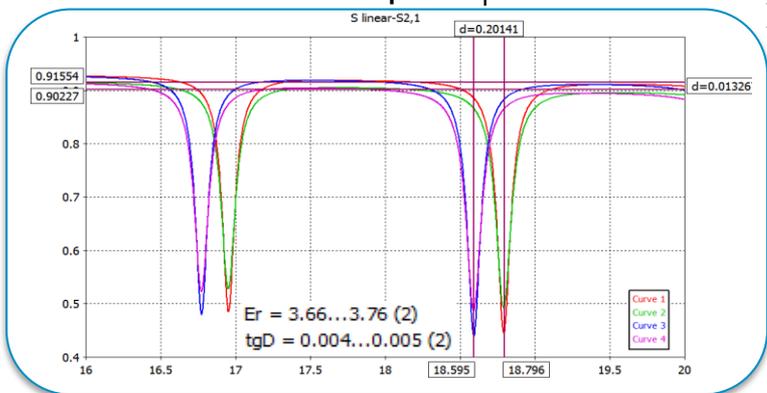
- $f_{\text{res}} \Rightarrow \epsilon'$

- $|S_{21}| \Rightarrow \epsilon''$



Complex ϵ_r Extraction Algorithm

1. Parameter sweep of ϵ_r and $\tan\delta$



2. Sensitivity of freq. and S_{21}

$$sensf = \frac{\Delta f}{\Delta \epsilon_r'}$$

$$sensS_{21} = \frac{\Delta |S_{21}|}{\Delta \epsilon_r''}$$

3. "Correction" factor

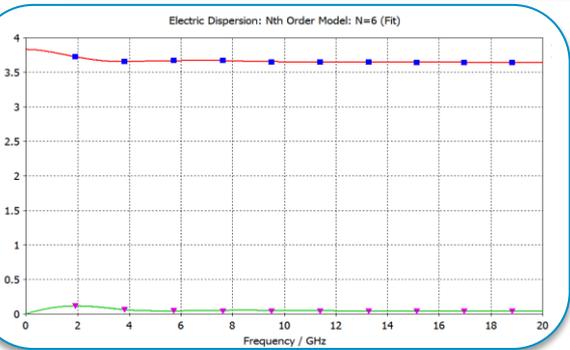
$$\Delta \epsilon_r' = \frac{f_{sim} - f_{meas}}{sensf}$$

$$\Delta \epsilon_r'' = \frac{|S_{21}|_{sim} - |S_{21}|_{meas}}{sensS_{21}}$$

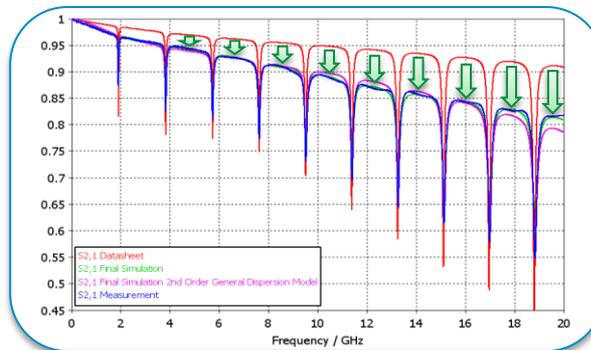
NO

Freq. [GHz]	Eps'	Eps''
1.912788	3.72363	1.140328e-1
3.8264725	3.6559328e+000	5.7550857e-002
5.7341705	3.6706356e+000	4.3679197e-002
7.6298955	3.6711876e+000	4.0248729e-002
9.515643	3.6489617e+000	3.8845006e-002
11.393409	3.6482667e+000	3.7751987e-002
13.263192	3.6448654e+000	3.7079645e-002
15.122998	3.6408623e+000	3.5987710e-002
16.972827	3.6387886e+000	3.7337948e-002
18.814673	3.6362939e+000	3.8063682e-002

4. Define materials

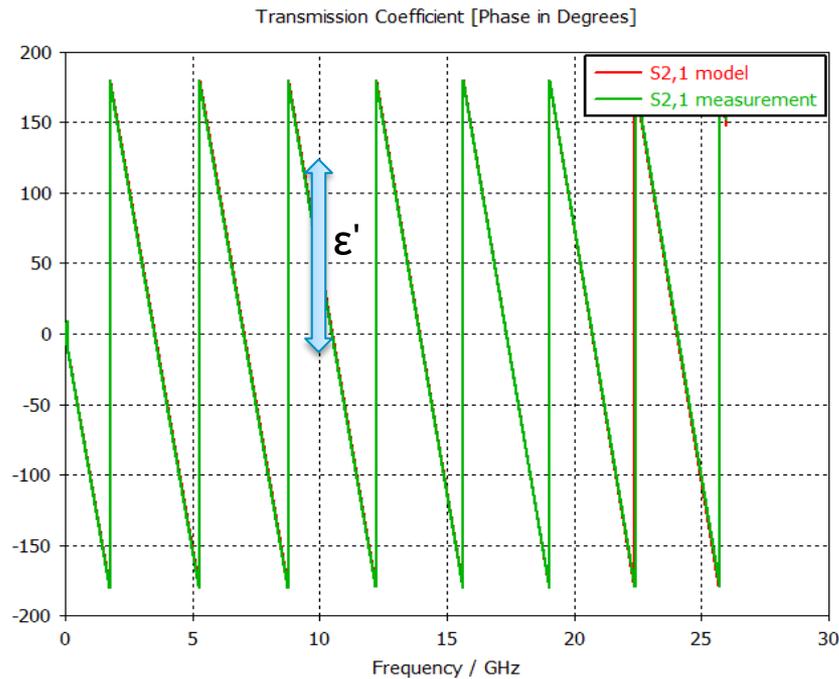
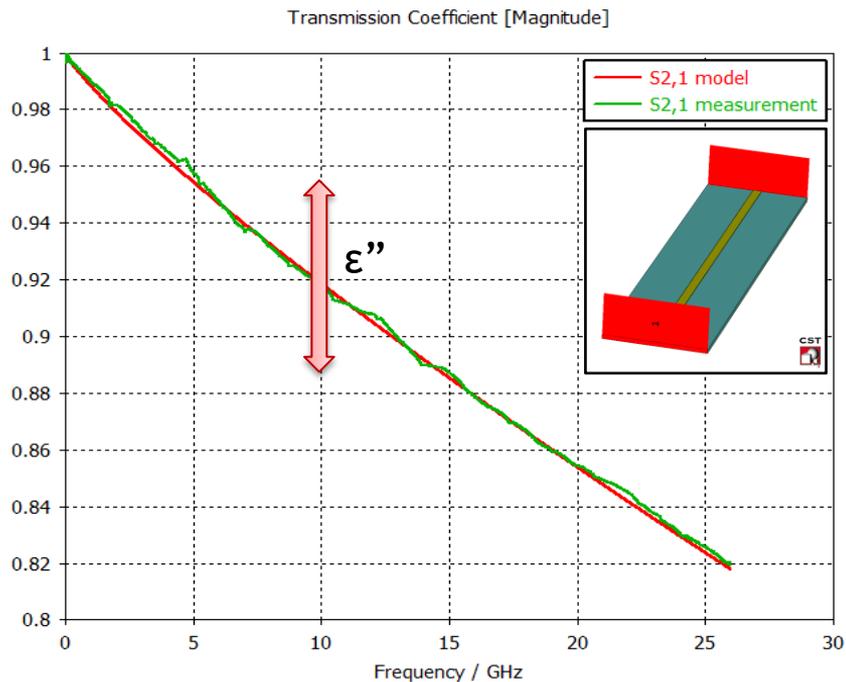


6. Dielectric properties



5. Simulation = Measurement?

TL Propagation Constant Technique



The measured S_{21} of homogeneous transmission line section is used for an extraction of substrate complex permittivity. Please note that transmission coefficient S_{21} is equal to $\exp(-\Gamma L)$ or “ $\epsilon\gamma L$ ”, where Γ is the propagation constant and L is the length of TL.

Automated Material Extraction Macro

Automatic Extraction Macro

Extract complex permittivity (broadband)

Select extraction technique

1. TL5e (3D EM extraction) (a)
 Import propagation constant (egL) (3D EM extraction) (b)
 TL5e w/o permittivity extraction (DUT) (c)

Material properties (datasheet)

Er' Er'' Loss tangent

Select material

Load measured data (TOUCHSTONE)

line_67mm_mask_measured.s2p

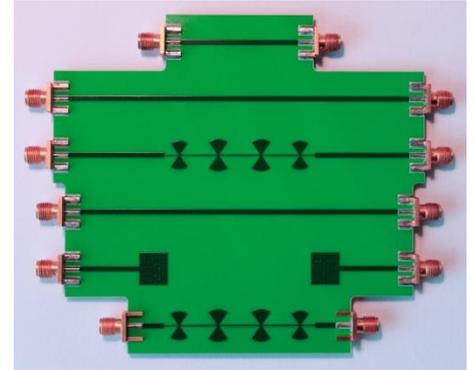
Length difference between THRU and LINE mm

Transmission line length in 3D EM model mm

1(a) Extracts complex permittivity from measurement of two lines* (Thru, Line) using 3D EM line model.



1(b) Extracts complex permittivity from directly measured S-parameters of a section of homogeneous transmission line (transmission coefficient egL) stored in Touchstone file using 3D EM line model. Multiline calkit and NIST Multiline TRL calibration technique is usually used for this option.



1(c) Extracts DUT S-parameters using just Thru and Line calibration standards*.



* 1st tier calibration at coaxial line is required.

Automatic Extraction Macro

Extract complex permittivity (broadband)

Select extraction technique

TL5e (3D EM extraction)

Import propagation constant (egL) (3D EM extraction)

TL5e w/o permittivity extraction (DUT)

Material properties (datasheet)

2. Er' 3.66 Er'' 0.01464 Loss tangent 0.004

Select material RD4350

Load measured data (TOUCHSTONE)

Prop. const. (egL) line_67mm_mask_measured.s2p

THRU Std.

LINE Std.

DUT

Length difference between THRU and LINE 67 mm

Transmission line length in 3D EM model 67 mm

Extract Cancel Specials... Logfile Help

- Initial guess of the dielectric constant ϵ_r' and loss tangent tgD . Datasheet data are usually used. Material to be used for the extraction in 3D EM model is selected in the drop list.

Automatic Extraction Macro

Extract complex permittivity (broadband)

Select extraction technique

TL5e (3D EM extraction)

Import propagation constant (egL) (3D EM extraction)

TL5e w/o permittivity extraction (DUT)

Material properties (datasheet)

Er' 3.66 Er'' 0.01464 Loss tangent 0.004

Select material RD4350

Load measured data (TOUCHSTONE)

Prop. const. (egL) line_67mm_mask_measured.s2p

THRU Std.

LINE Std.

DUT

Length difference between THRU and LINE 67 mm

Transmission line length in 3D EM model 67 mm

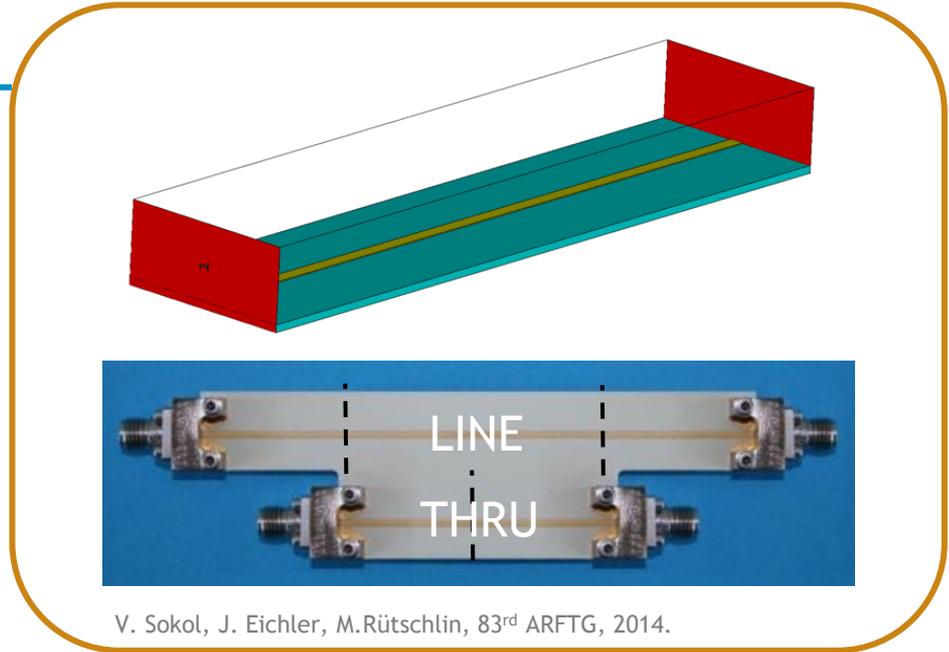
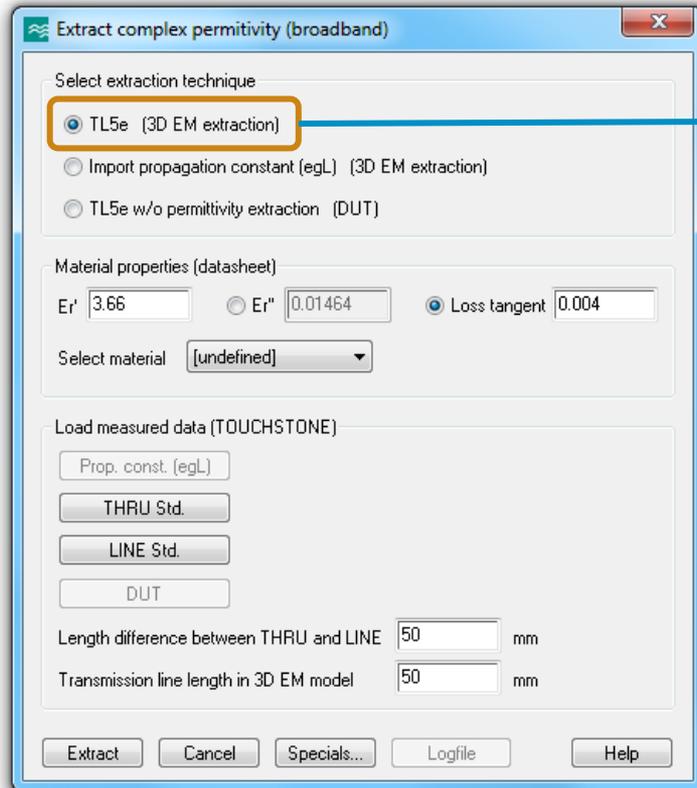
Extract Cancel Specials... Logfile Help

3.

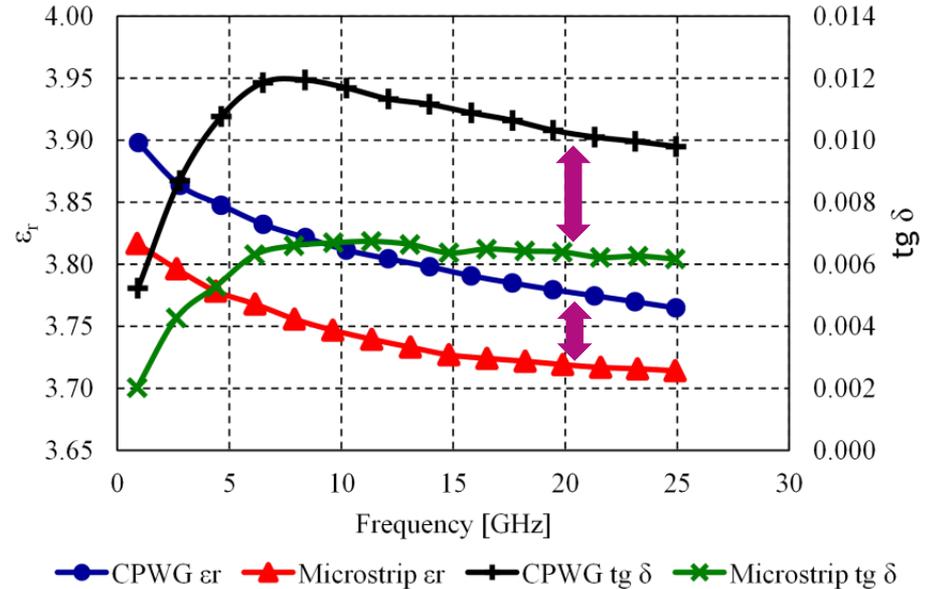
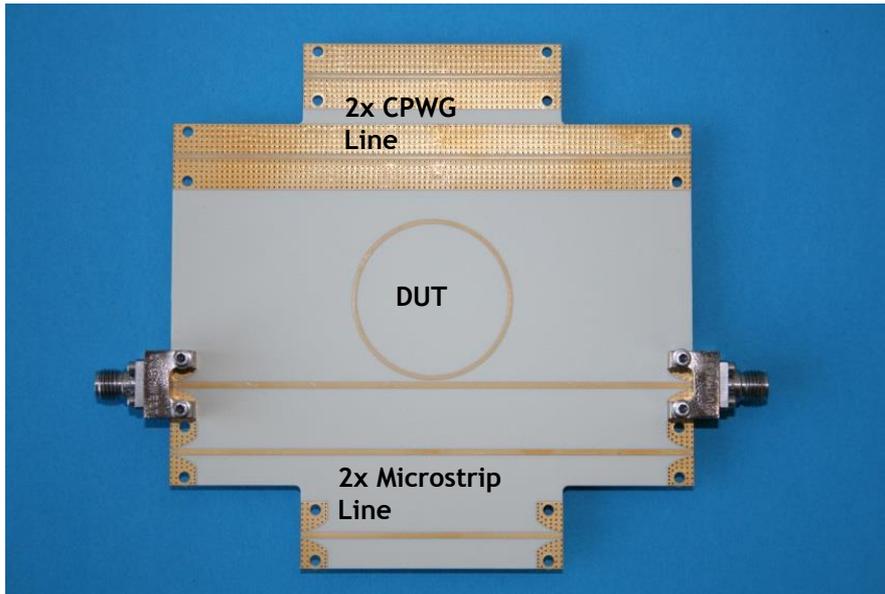
3. Measured S-parameters are loaded here as Touchstone files.

Transmission line length in 3D EM model can be reduced in case the length of the measured sample is too long. Then the measured transmission coefficient is scaled down to fit the length of the 3D EM model.

Two Transmission Line

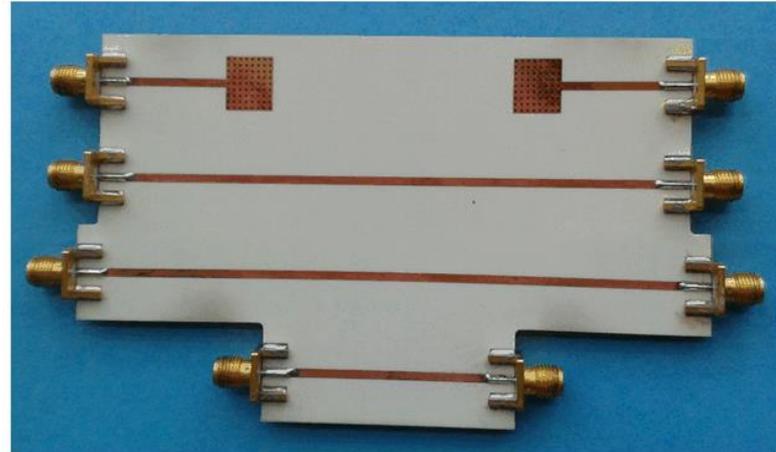
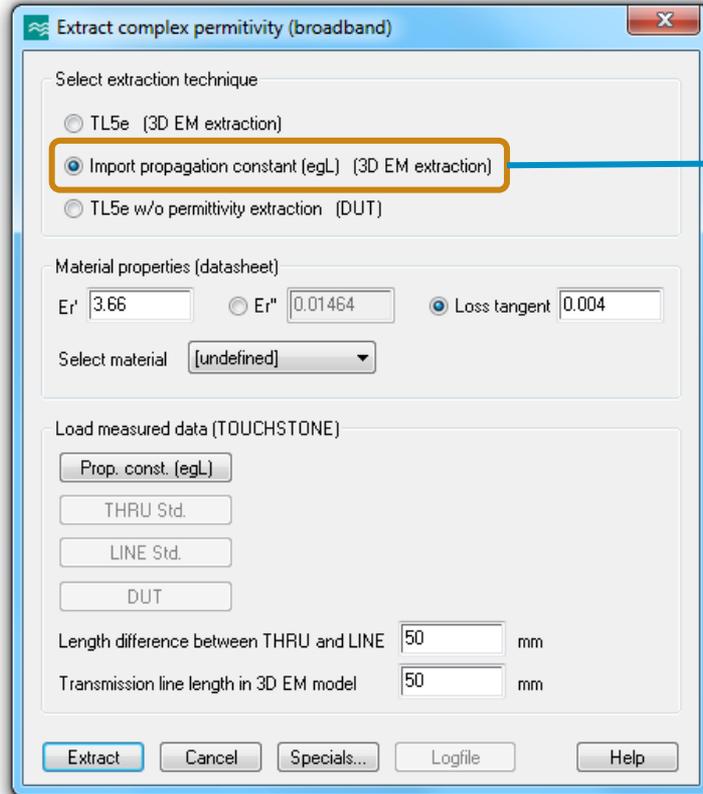


Two Transmission Line



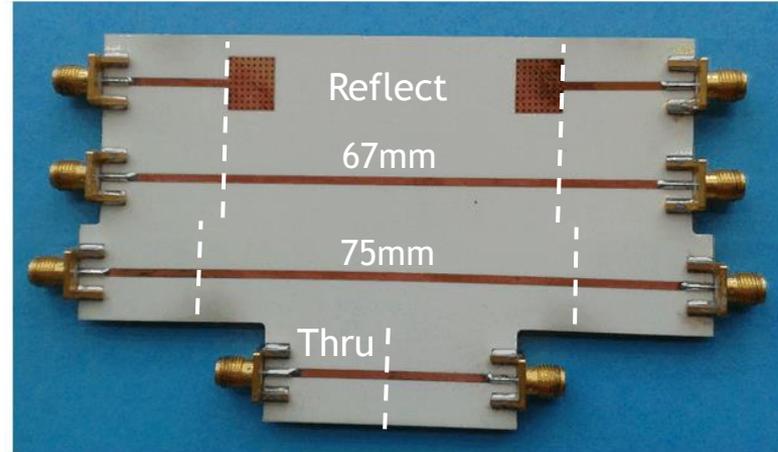
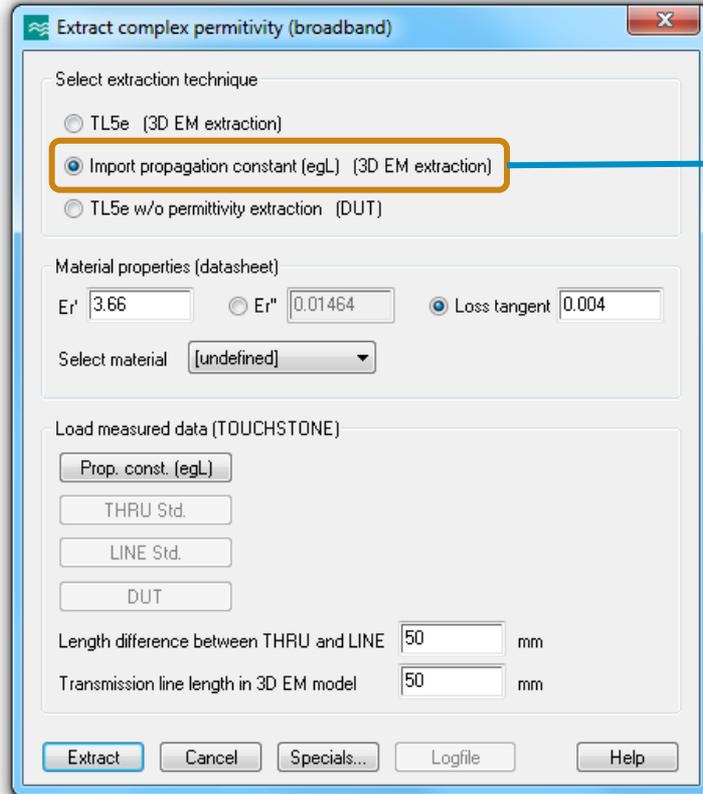
V. Sokol, J. Eichler, M. Rütshlin, 83rd ARFTG, 2014.

NIST Multiline TRL



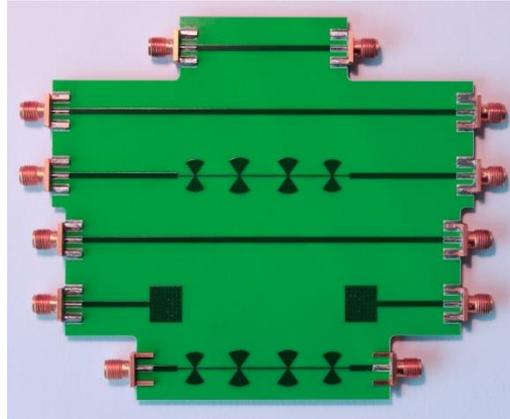
Marks, Roger B., "A multiline method of network analyzer calibration," *Microwave Theory and Techniques, IEEE Transactions on*, vol.39, no.7, pp.1205,1215, Jul 1991

NIST Multiline TRL

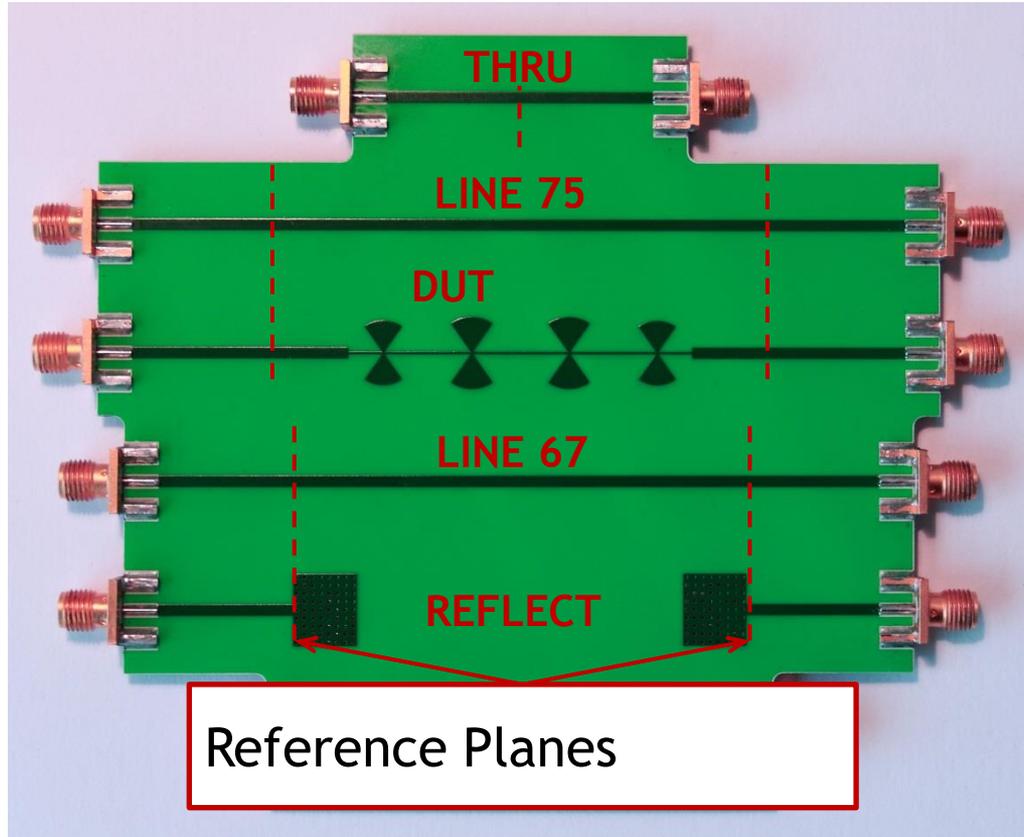


$$\tau = \frac{l}{c / \sqrt{\epsilon_{ef}}}$$

Multiline TRL examples



Multiline TRL - Microstrip



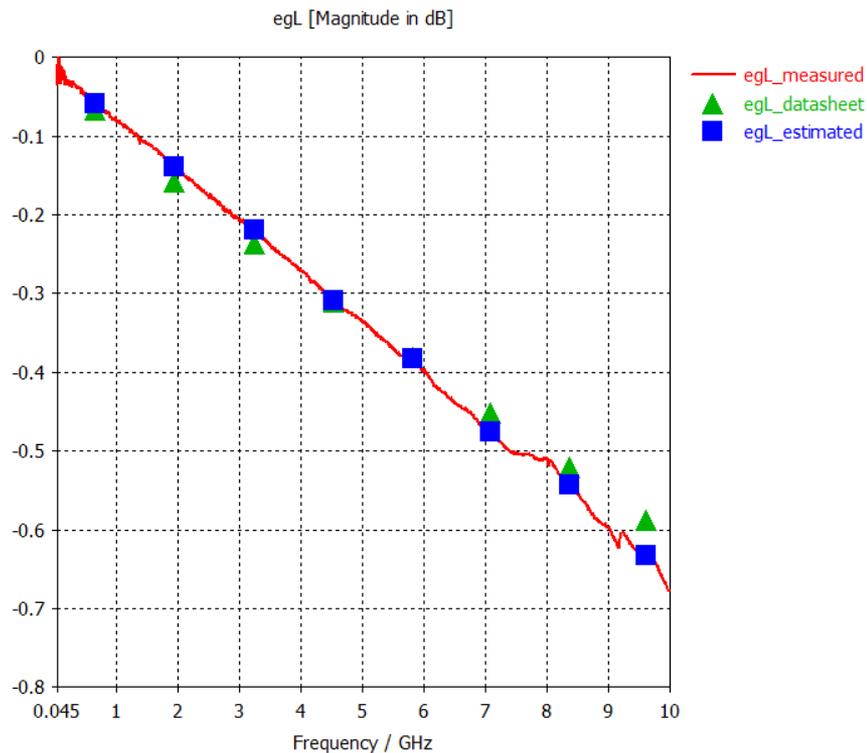
Time-delay calculation for LINE standards (67 and 75 mm):

$$\tau = \frac{l}{c / \sqrt{\epsilon_{ef}}}$$

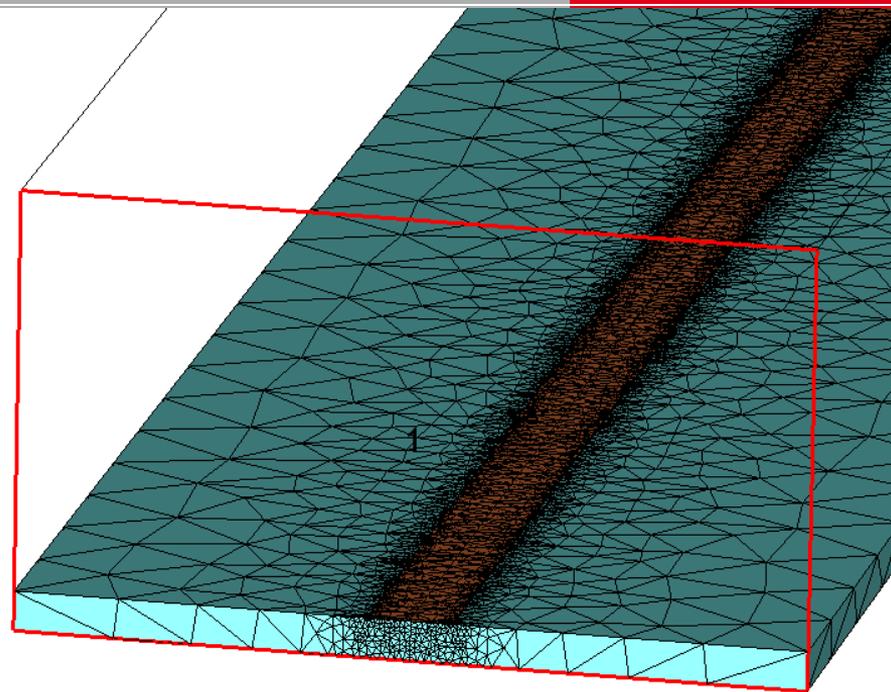
$$\tau_1 = \frac{0.067}{c / \sqrt{2.9}} = 381 \text{ ps}$$

$$\tau_2 = \frac{0.075}{c / \sqrt{2.9}} = 427 \text{ ps}$$

Multiline TRL - Microstrip



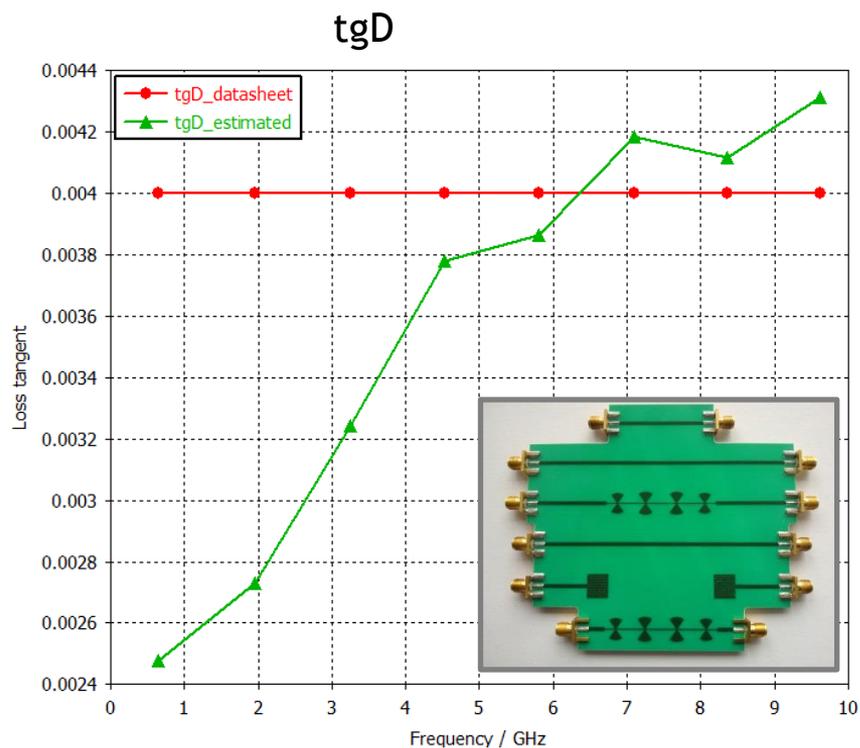
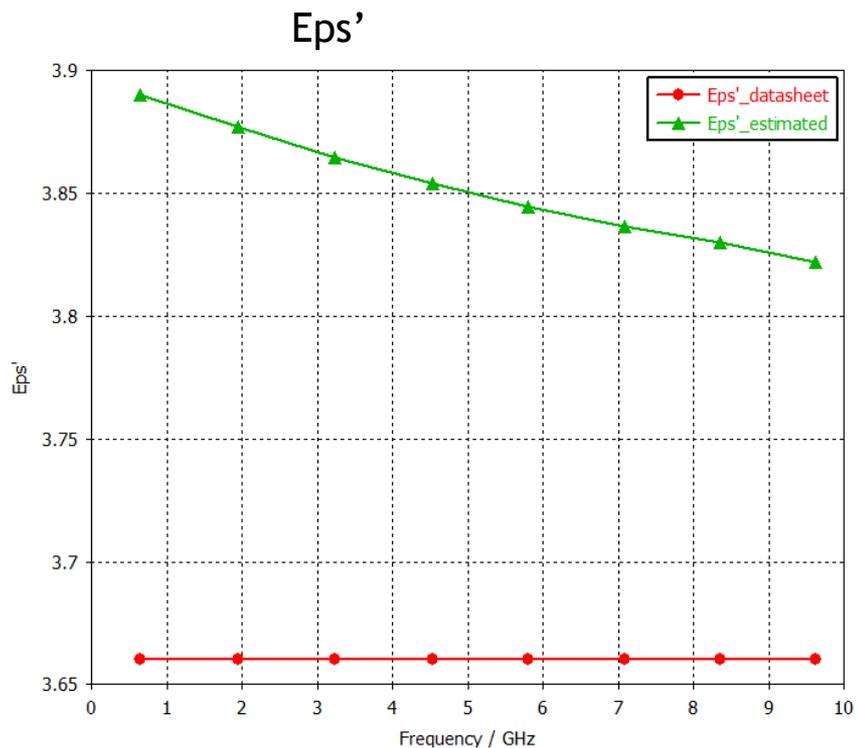
Line 67 mm S21 (egL) is used for the extraction here.



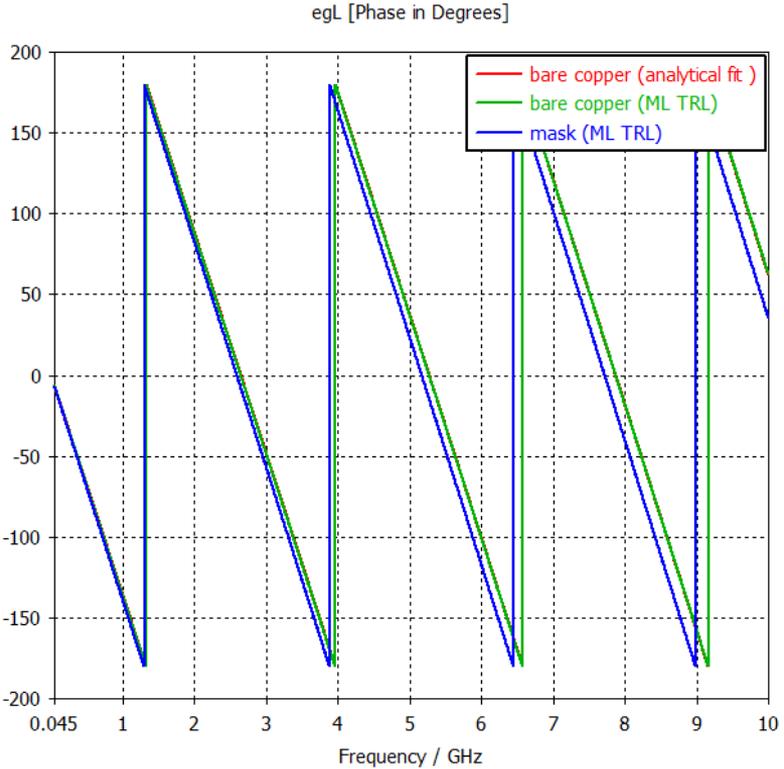
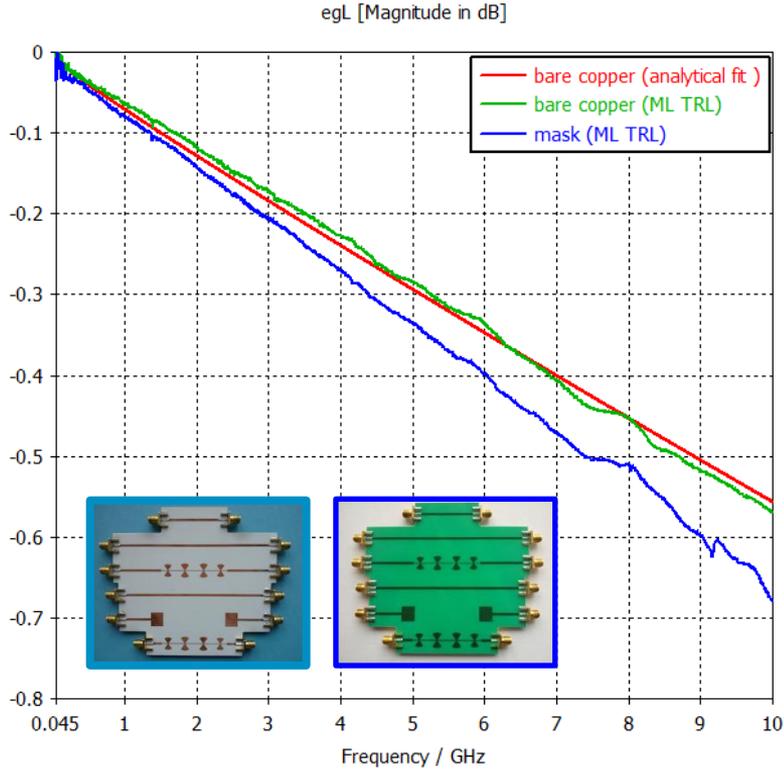
High Frequency Mesh
Tetrahedrons: 43107
Symmetries: xz

i Max. phase deviation: 2.87529624441959e-1 deg
Max. magnitude deviation: 9.77502528792806e-5 (linear)
i Extraction finished after 3 iterations in 8 min 55 s

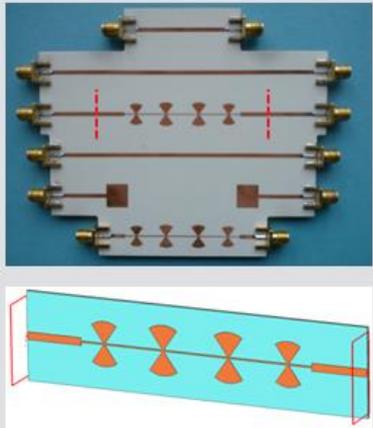
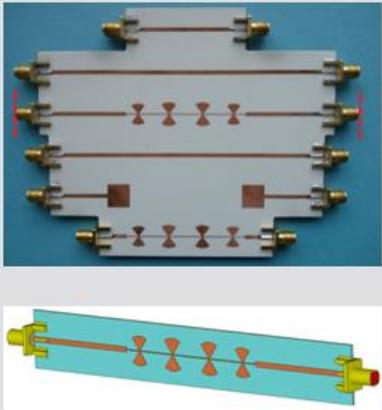
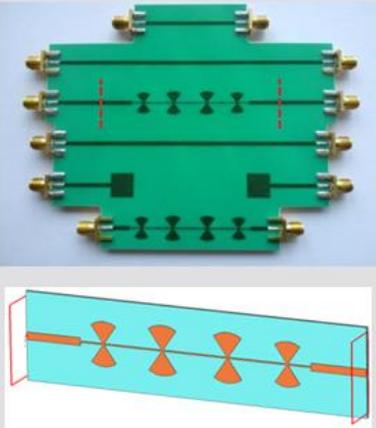
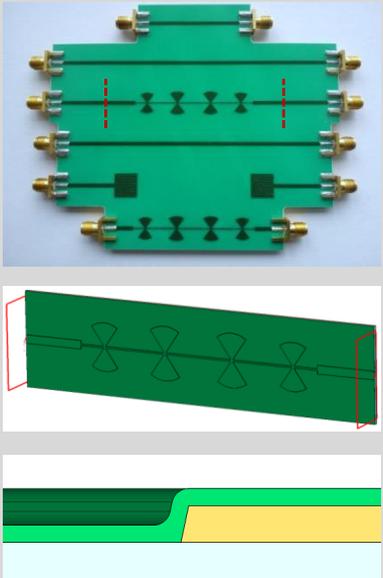
Multiline TRL - Microstrip



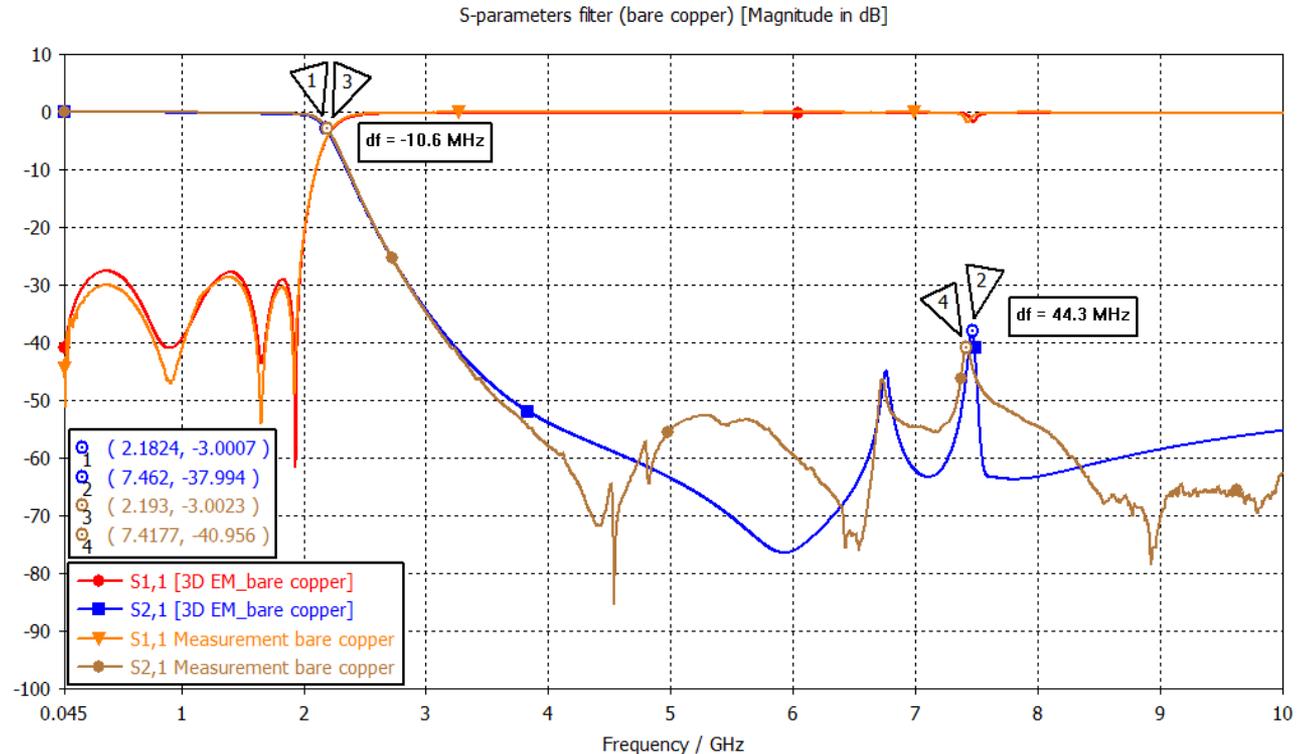
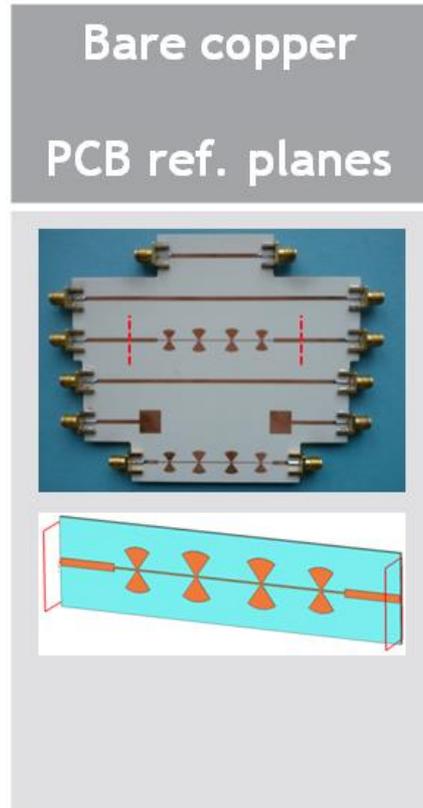
Bare Copper versus Solder Mask



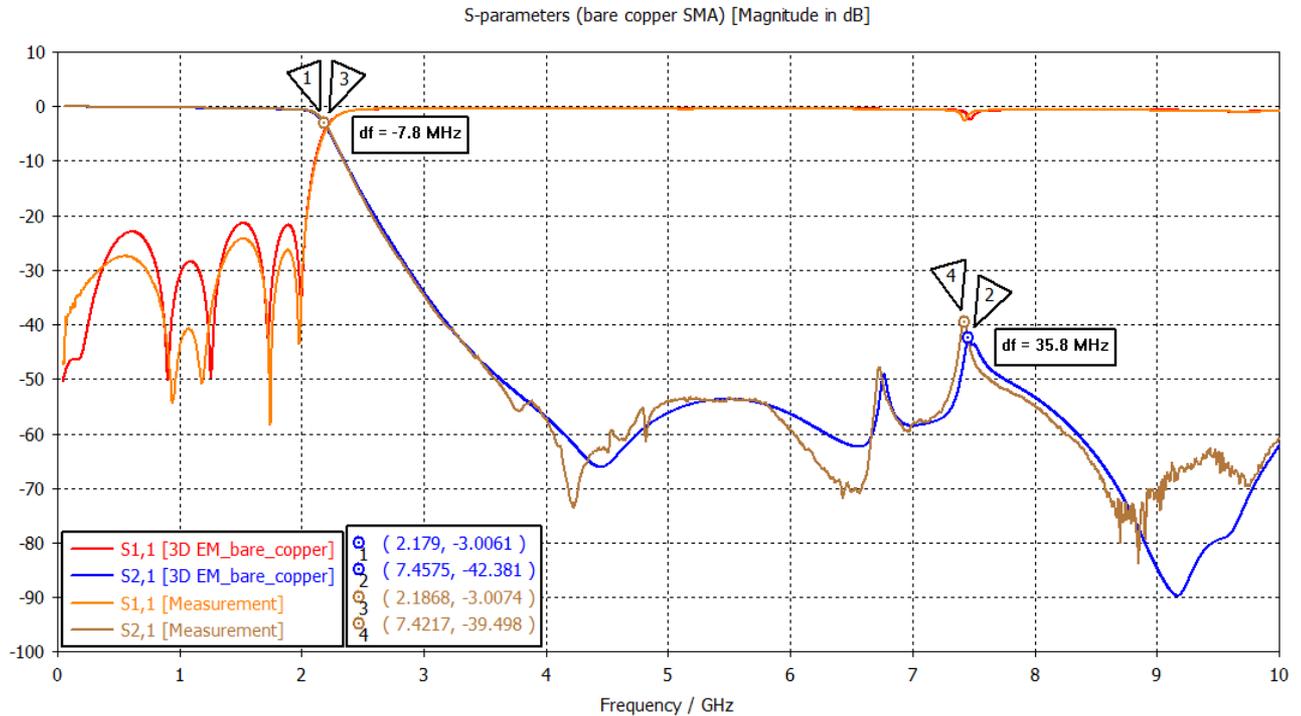
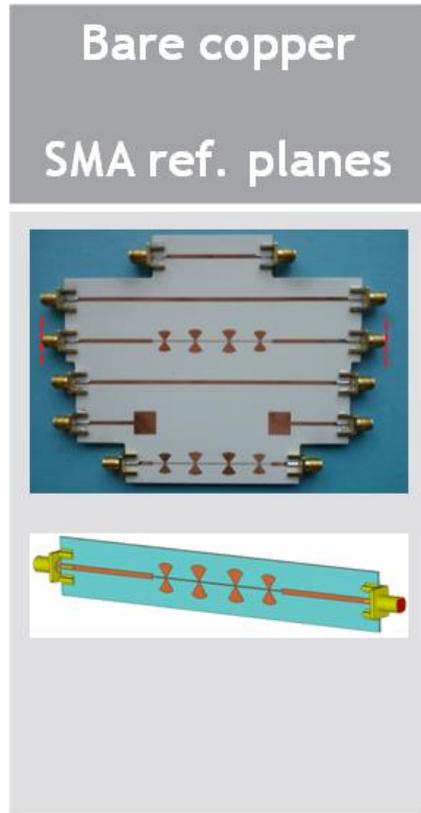
Low-Pass Filter

Bare copper PCB ref. planes	Bare copper SMA ref. planes	Solder mask (integrated) PCB ref. planes	Solder mask (extra layer) PCB ref. planes
 <p>The photograph shows a white PCB with a central filter section. Red dashed lines indicate the reference planes. The cross-section shows a blue dielectric core with a central copper conductor and four red filter elements.</p>	 <p>The photograph shows a white PCB with SMA connectors at the ends. The cross-section shows a blue dielectric core with a central copper conductor and four red filter elements, with SMA connectors at the ends.</p>	 <p>The photograph shows a green PCB with a central filter section. Red dashed lines indicate the reference planes. The cross-section shows a blue dielectric core with a central copper conductor and four red filter elements.</p>	 <p>The photograph shows a green PCB with a central filter section. Red dashed lines indicate the reference planes. The cross-section shows a blue dielectric core with a central copper conductor and four red filter elements, with an extra solder mask layer on top.</p>

Low-Pass Filter (Bare Copper)

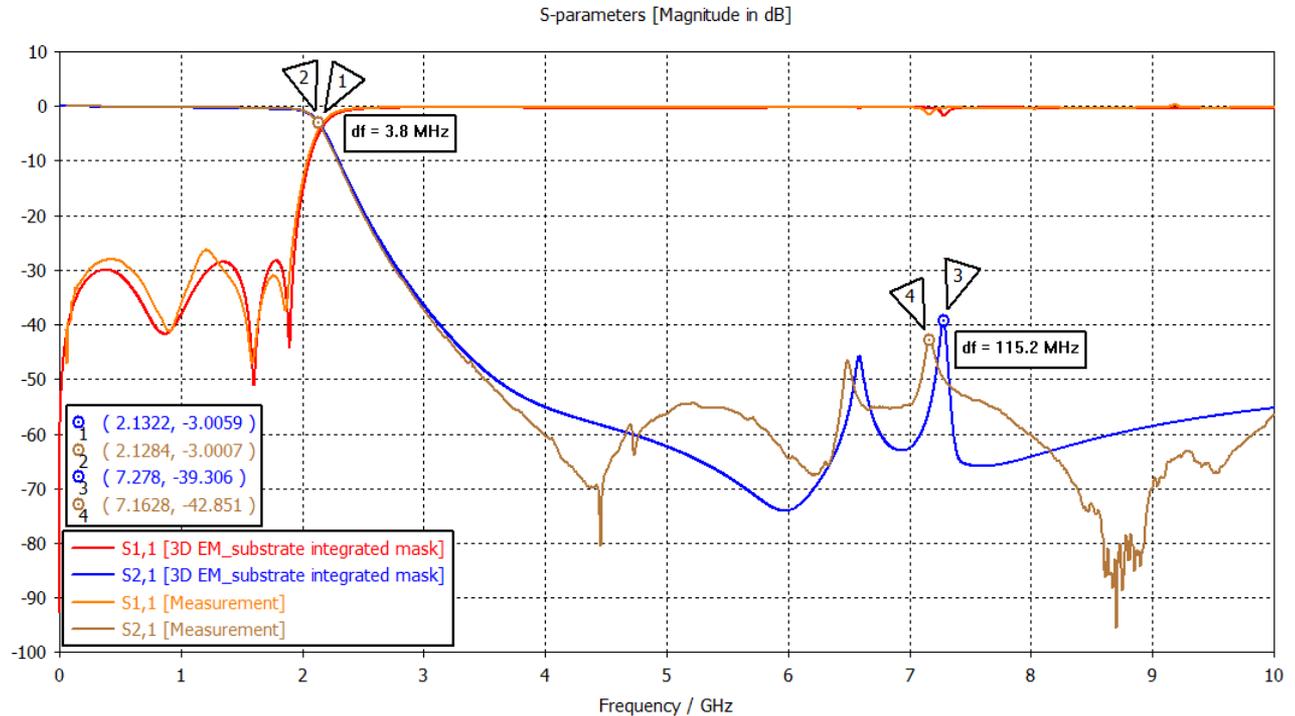
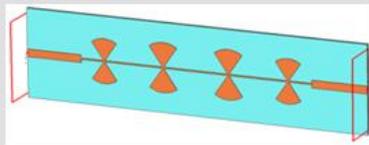
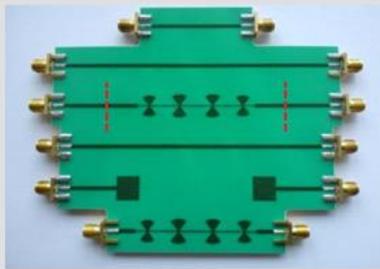


Low-Pass Filter (Bare Copper at SMA)



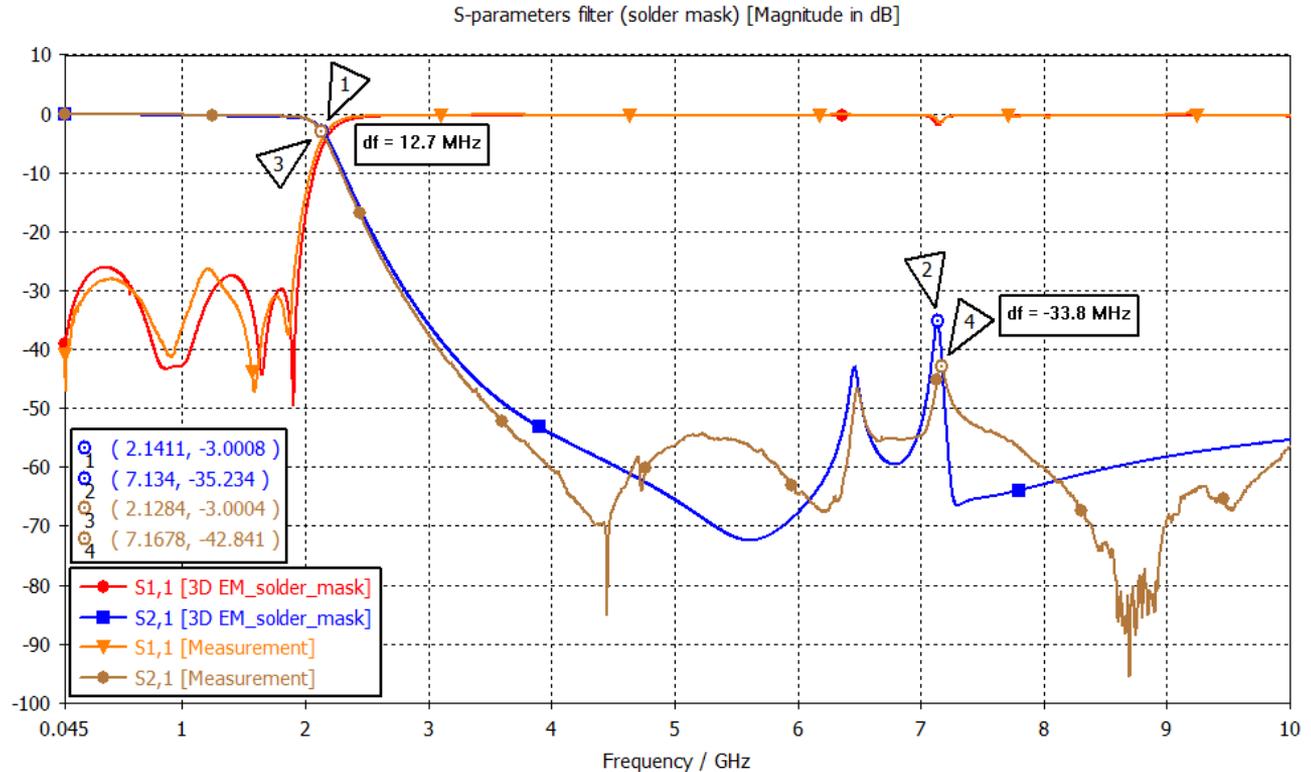
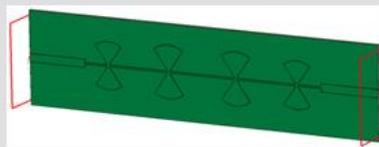
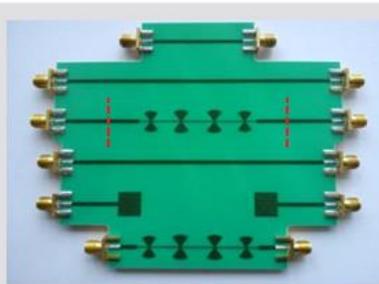
Low-Pass Filter (Integrated Mask)

Solder mask
(integrated)
PCB ref. planes

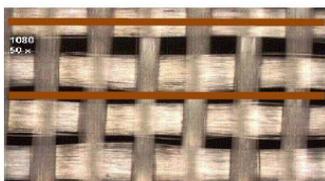
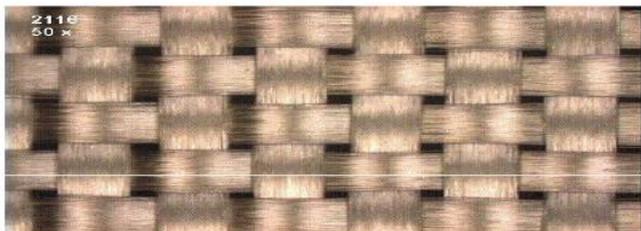


Low-Pass Filter (Mask As Extra Layer)

Solder mask
(extra layer)
PCB ref. planes

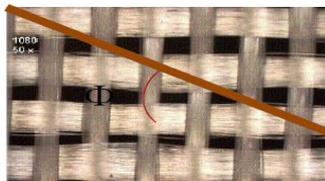


Composite Materials - Glass Weave

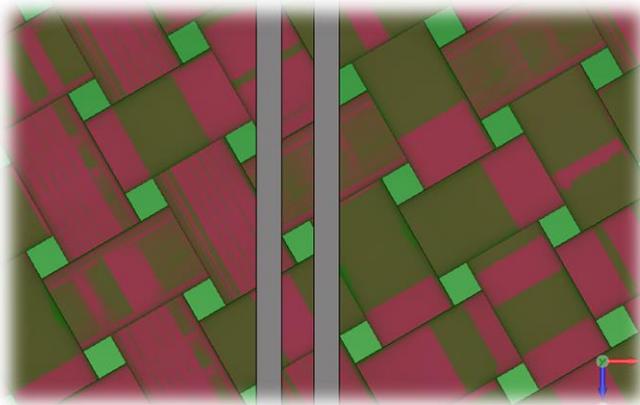


High ϵ_r ;
Low Z_0

Low ϵ_r ;
High Z_0



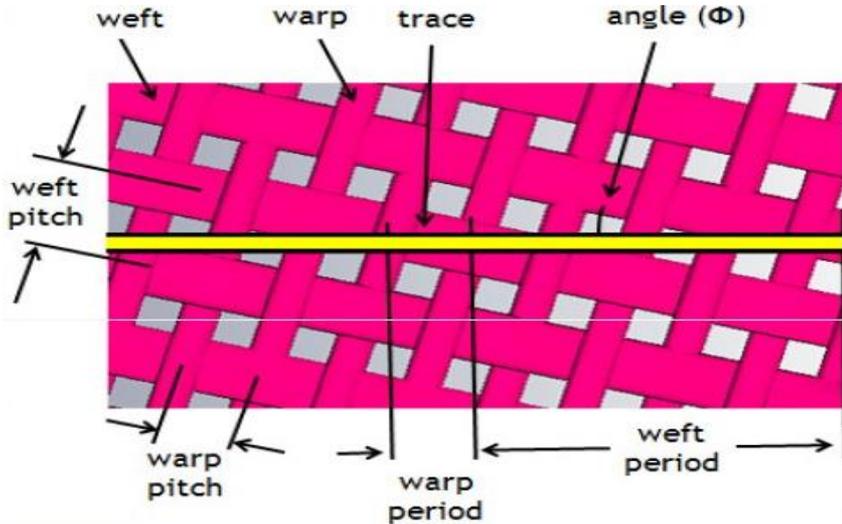
Effects originate from the inhomogeneous properties of PCB laminates



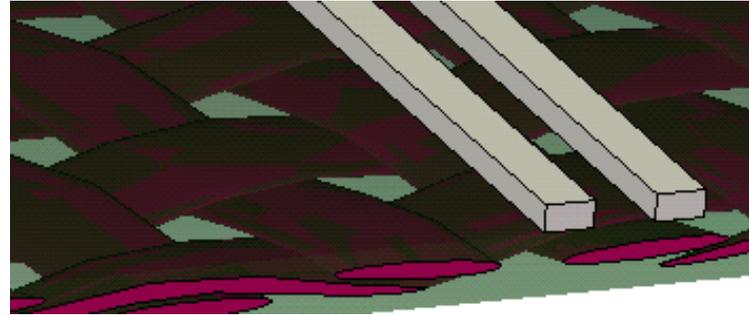
The location of trace versus fiber weave influences impedance, dielectric parameters, and can cause resonance.

Reference: G. Romo, M Schauer, et Al, "Stack-up and routing optimization by understanding micro-scale PCB Effects", presented at DesignCon 2011

Glass Weave



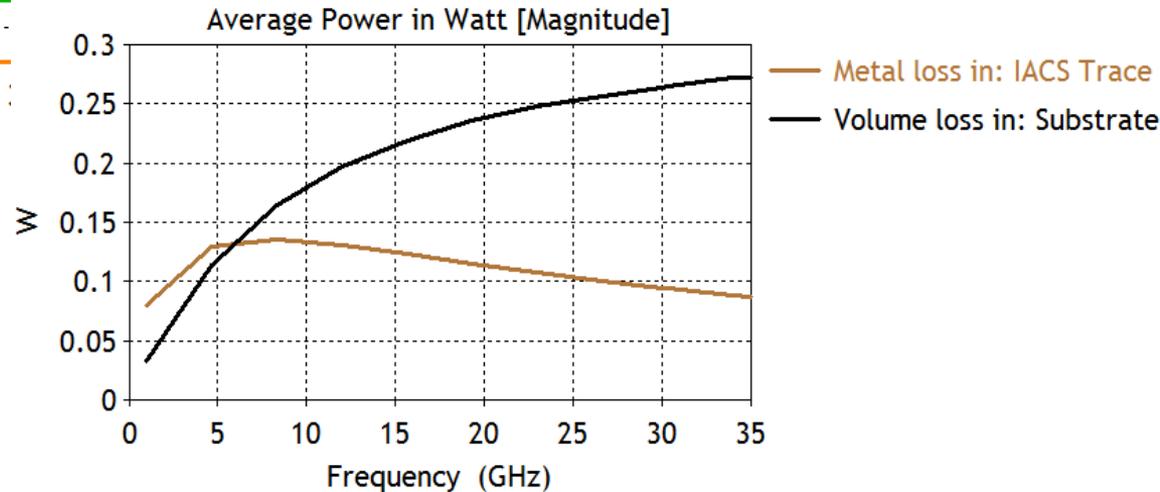
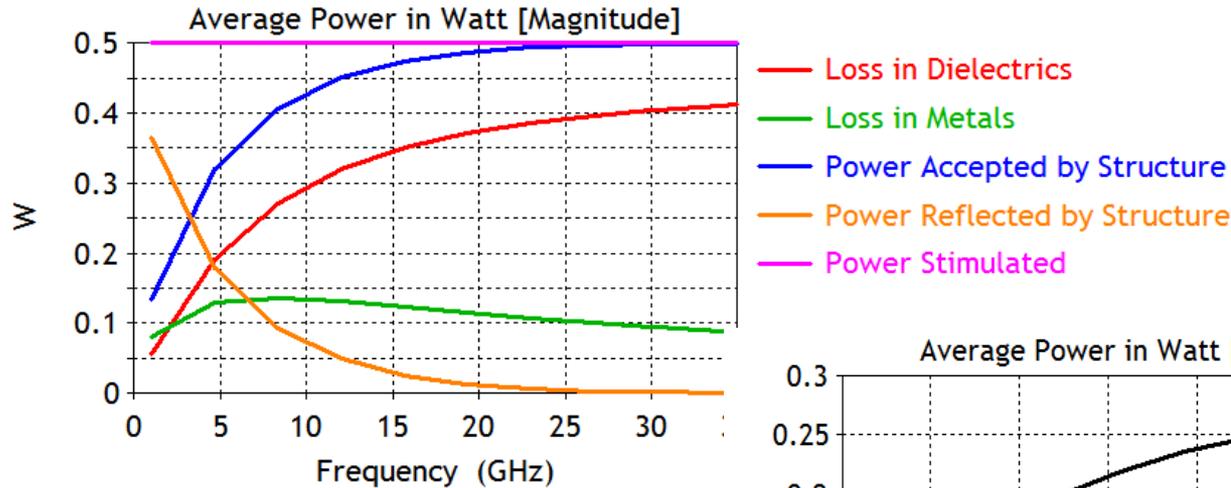
$$weftperiod = \sqrt{pitch^2 \left(\frac{1}{[\tan \phi]^2} + 1 \right)}$$



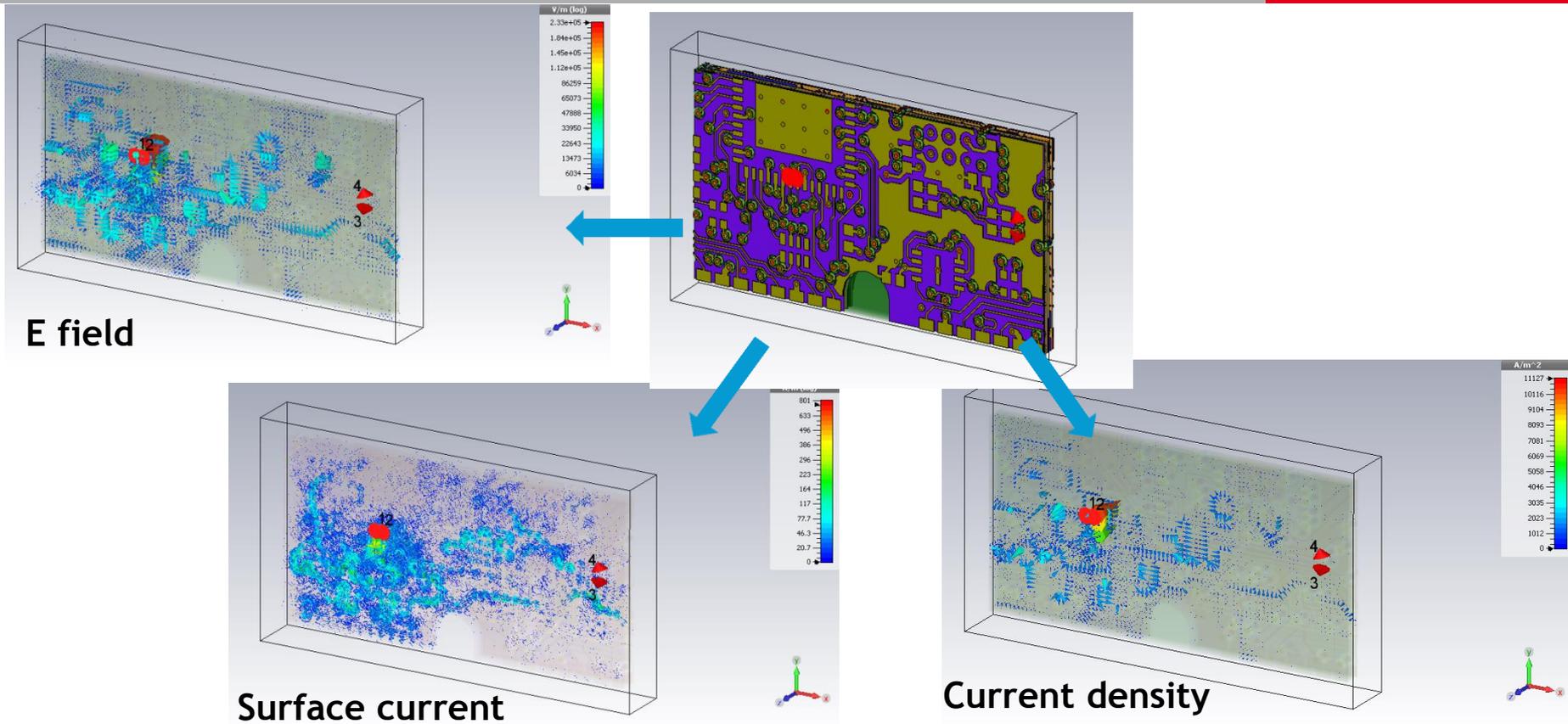
- Spatial period for sparse weave will impact effective permittivity and trace impedance
- Challenge to find spatial period; period depends on routing angle
- The Weft and Warp loading may have resonance effects

Extract parameters from detailed model

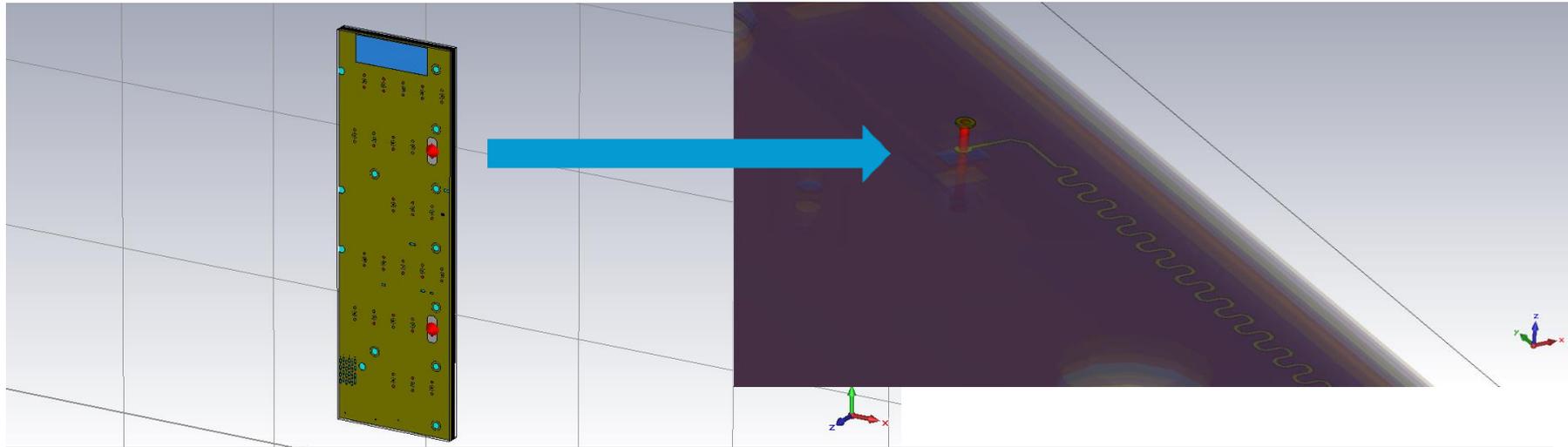
Where Does the Power go? Separating the Components



Where Does the Power go? Monitoring the Fields



Real Case Example

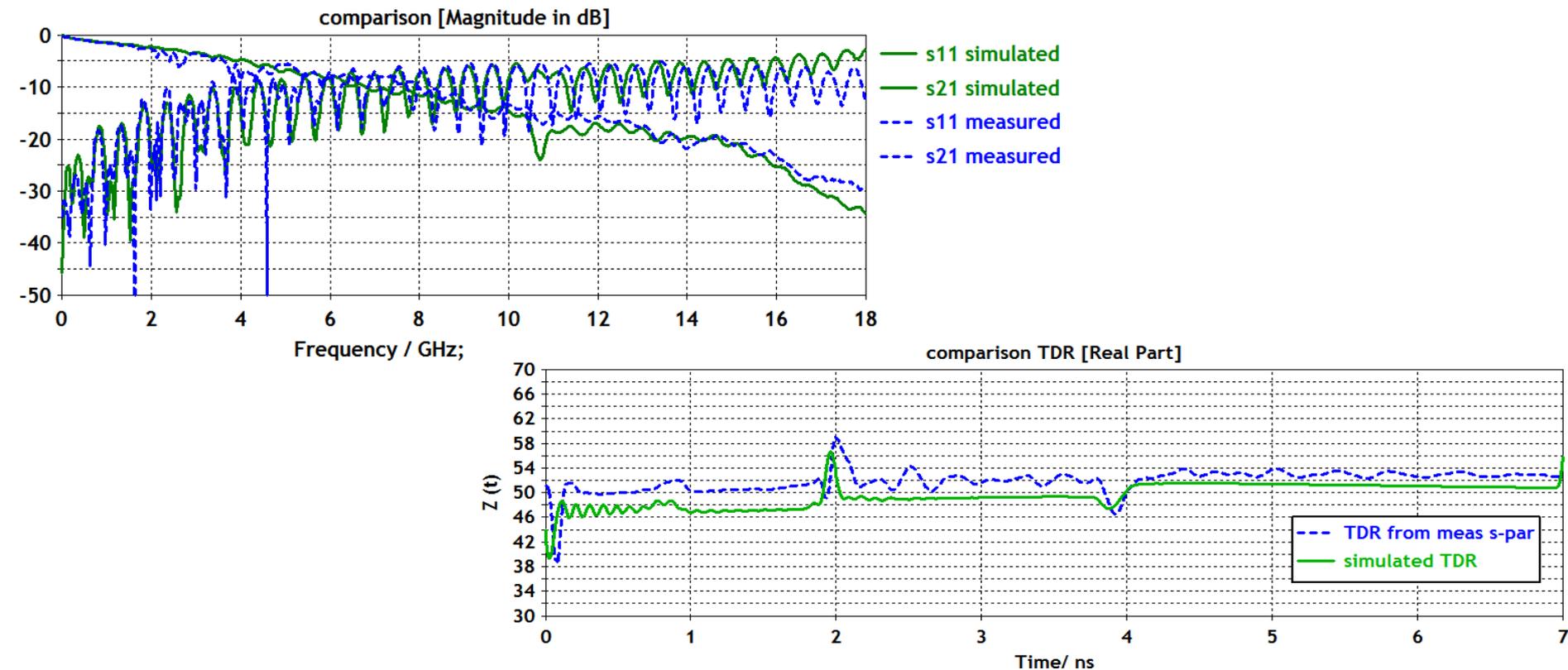


Materials properties

Dielectric: $\epsilon_s=3.6$, $\text{tg}\delta=0.01$ Debye 3rd order

Copper = $4.1e7$ S/m with inclusion of surface roughness with TSI (H&J model)

S-Parameter and TDR Results



Discussion

Conductor loss characterization

...before going directly to surface roughness:

- Accurate conductivity? Rare that metal trace is from pure element.
- Edge consideration? Weave influence?
- Other process changing the material characteristics?
- Try to include surface roughness.

Dielectric material characterization

- Accurate “Nth order” curve fit for T solver simulations.
- Measure/characterize yourself?

Conclusion

- Conductor and dielectric loss components significant and require careful parameterization for simulation. If you want accurate results.
- Simulation can help separate loss components and help the characterization process.
- Several strategies are available for the simulation of surface roughness. TSI good in some cases. Other strategies being developed.
- Knowledge really is power. Know your materials.
- Microscopic effects: surface roughness, nickel, glass weave etc, can be extracted from detailed models and parameterized for larger/faster models.

Thank you for your attention

Questions?